



**EECS151/251A**  
**Spring 2023**  
**Digital Design and**  
**Integrated Circuits**

Instructor:  
John Wawrzynek

**Lecture 25:**  
Clocks, Packaging, and Power  
Distribution

# Announcements

- ❑ Homework assignment 10 posted - due next Monday.
- ❑ HW 11 - final problem set - posted end of this week.
- ❑ Final project checkoffs will be Thursday of next week (RRR).
- ❑ Final reports will be due Monday at midnight of exam week.
- ❑ Apple has generously offered to offer prizes for the best projects this semester:
  - ❑ *The top ASIC project (2 students), & the top 3 FPGA projects (6 students)*
  - ❑ *The student can choose either an Apple Watch (SE GPS, 40mm) or Airpod Pro.*

# Announcements

## □ End game:

	4/20	Multipliers, Shifters ( <a href="#">slides</a> )		
15	4/25	Clock and Power Distribution	Discussion 12	
	4/27	Wrap-up and Exam Review		
16	5/2	RRR No Lecture		
	5/4	RRR No Lecture		Final Checkoff (Report due midnight 5/8)
FINAL	5/10	No Class - Final Exam 7-10 PM		

# Outline

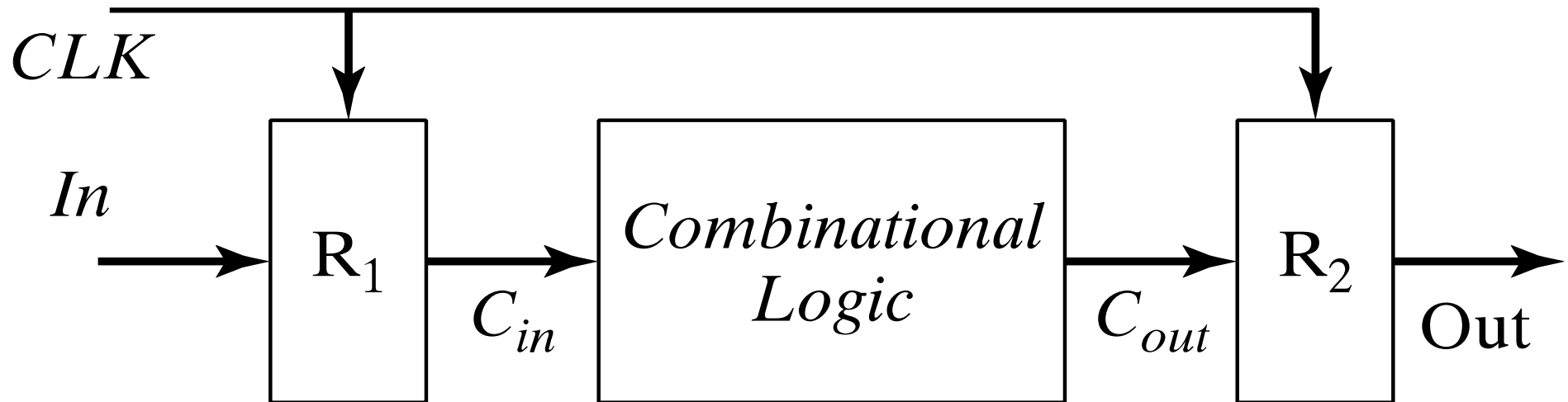


- ❑ Clock non-idealities
- ❑ Clock Distribution
- ❑ Chip packaging
- ❑ Power Distribution

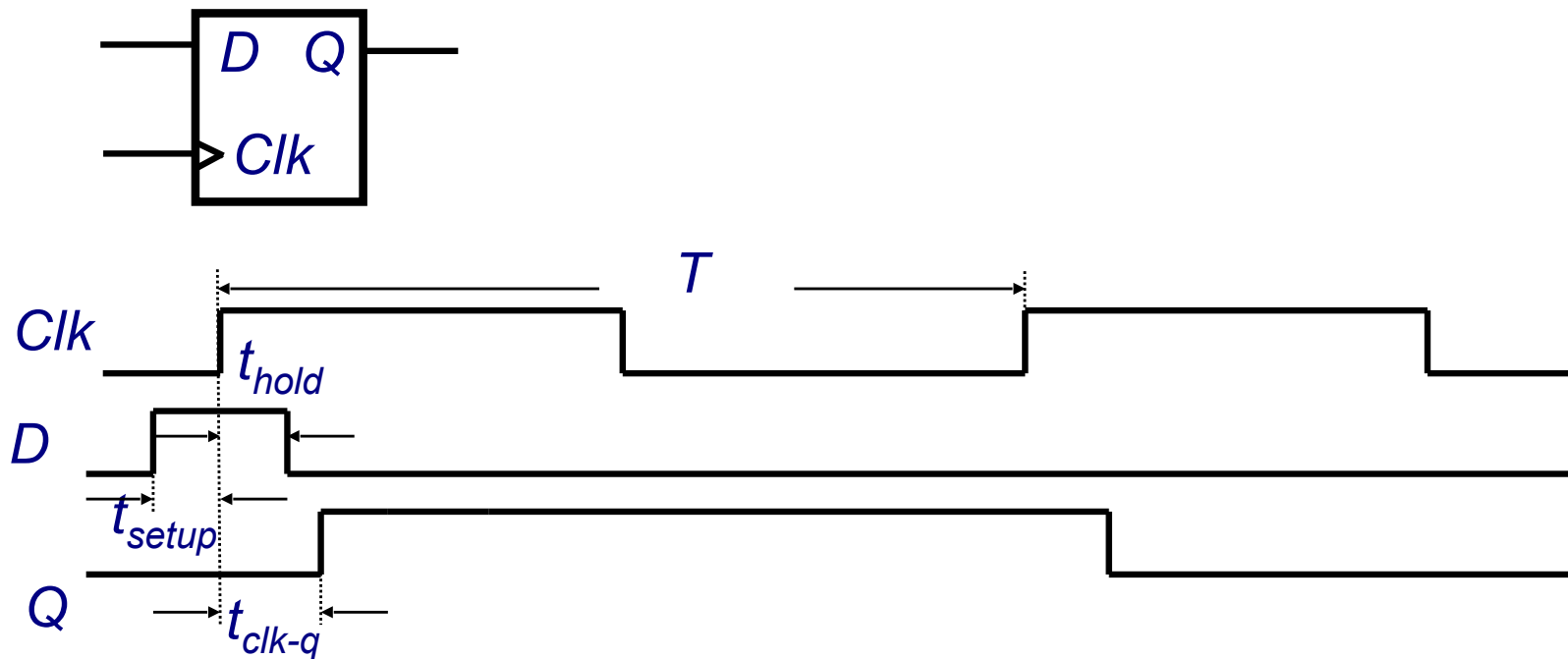


## **Synchronous Timing - Review**

# Synchronous Timing

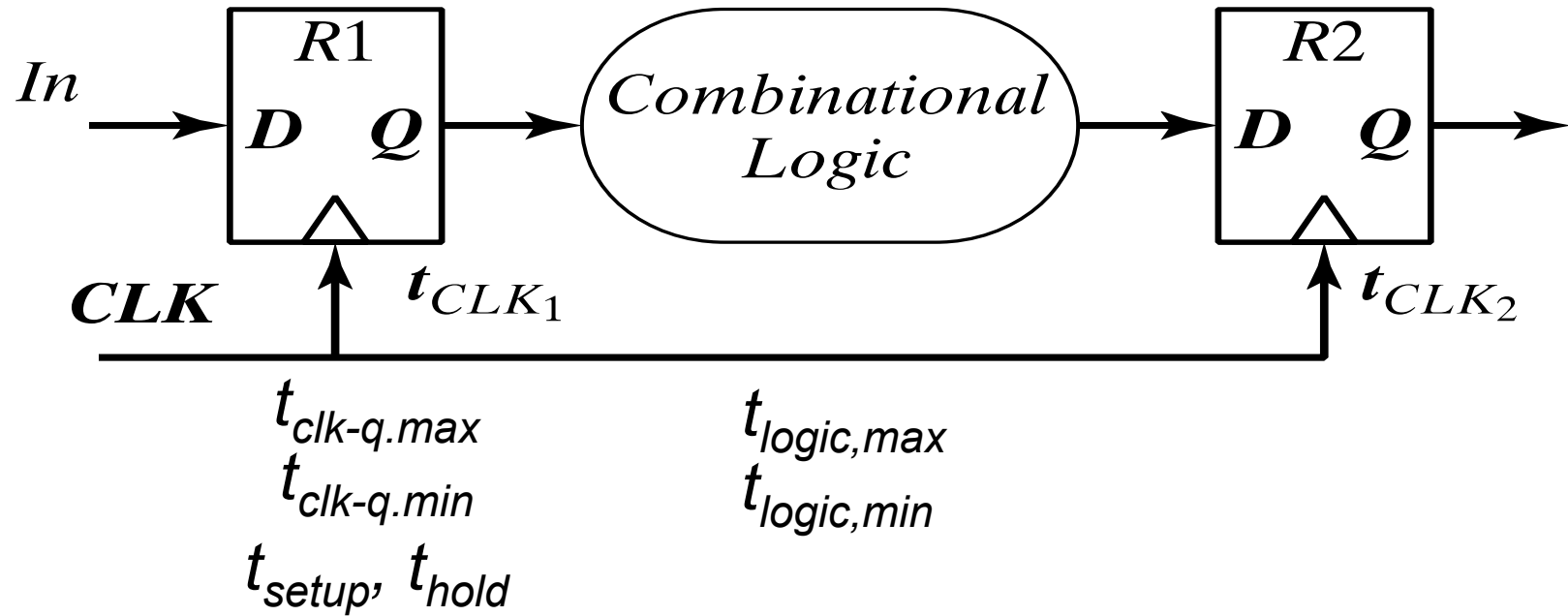


# Register Timing Parameters



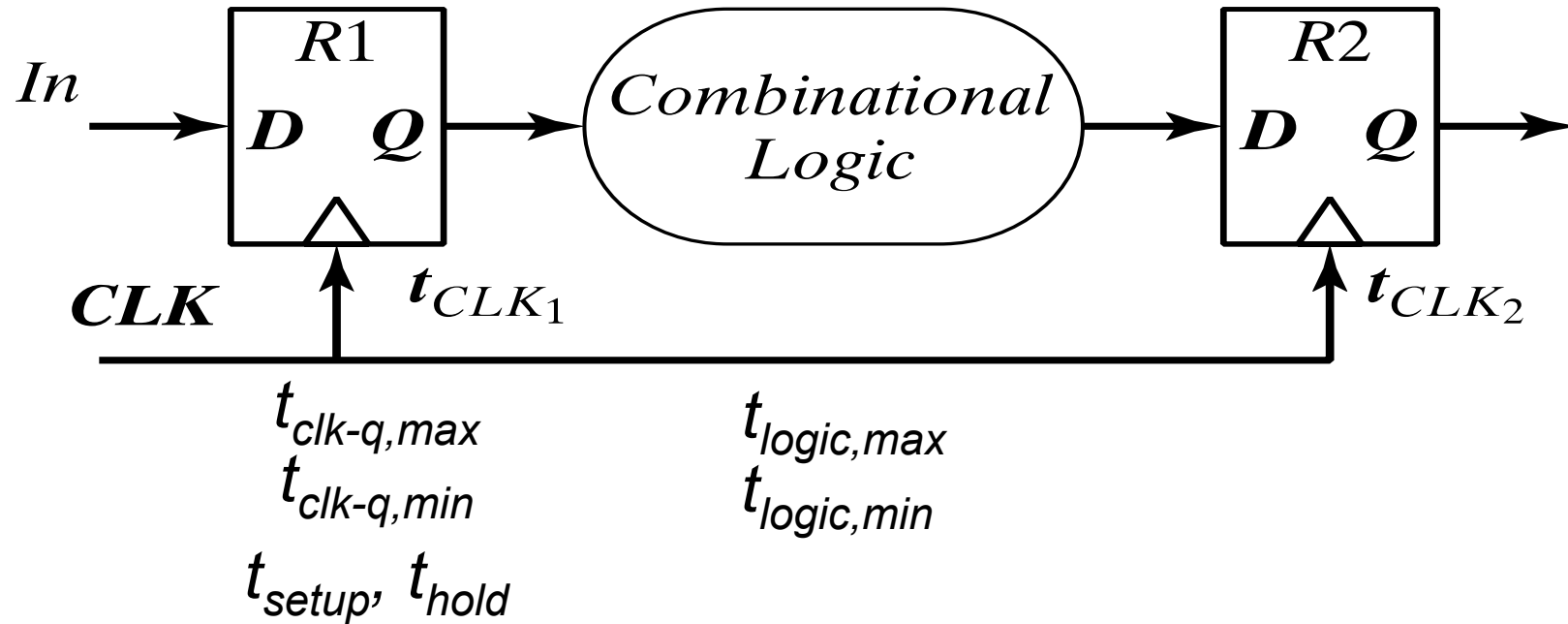
*Output delays can be different for rising and falling data transitions*

# Timing Constraints





# Timing Constraints



$$\text{Cycle time: } T_{clk} > t_{clk-q,max} + t_{logic,max} + t_{setup}$$

$$\text{Race margin: } t_{hold} < t_{clk-q,min} + t_{logic,min}$$



## **Clock Nonidealities**

# Clock Nonidealities

## □ Clock skew: $t_{SK}$

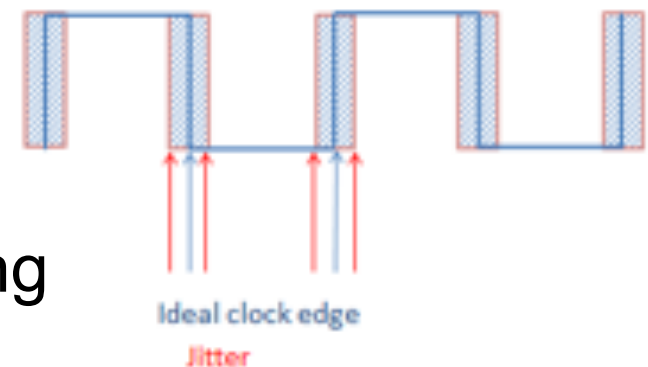
- Time difference between the arrival time of the clock signal at sink two different receivers

## □ Clock jitter

- Temporal variations in consecutive edges of the clock signal; modulation + random noise
- Cycle-to-cycle (short-term)  $t_{JS}$
- Long term  $t_{JL}$

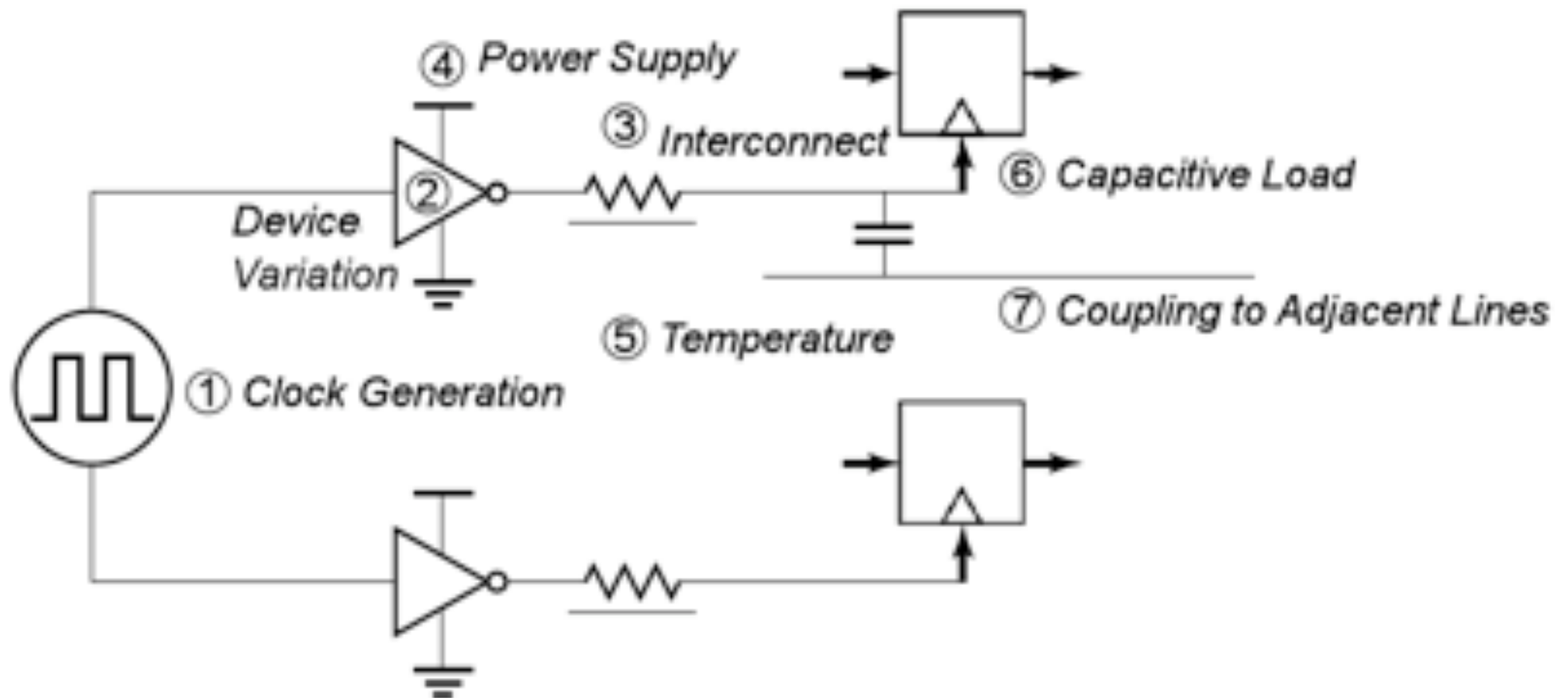
## □ Variation of the pulse width

- Important for level sensitive clocking

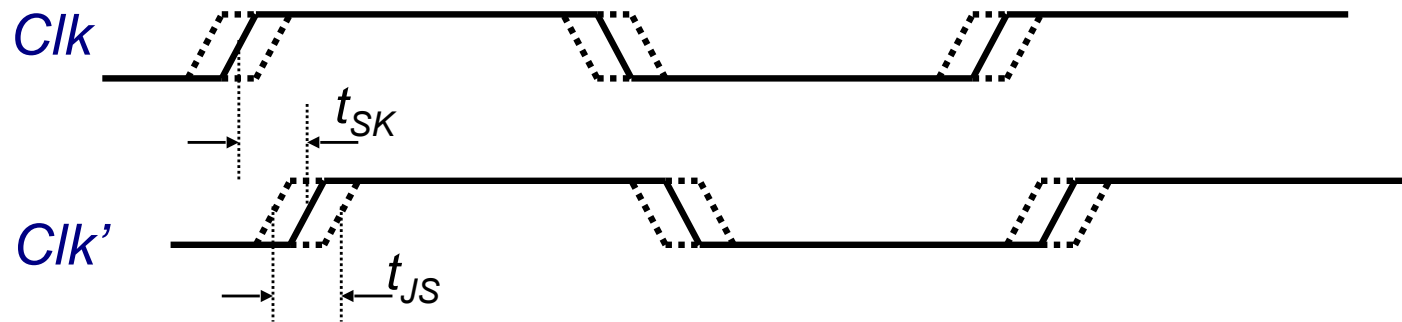


# Clock Uncertainties

*Sources of clock uncertainty*



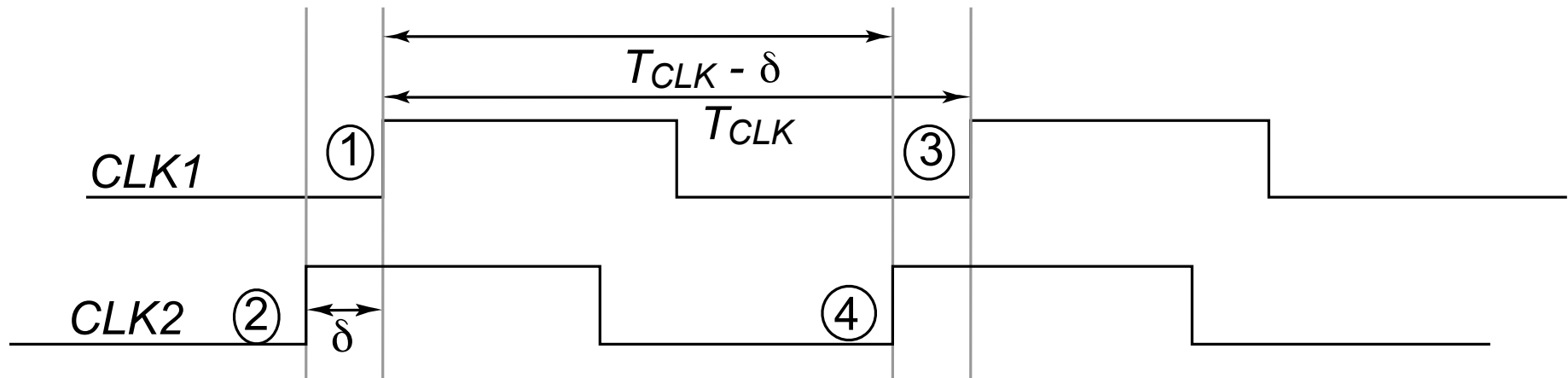
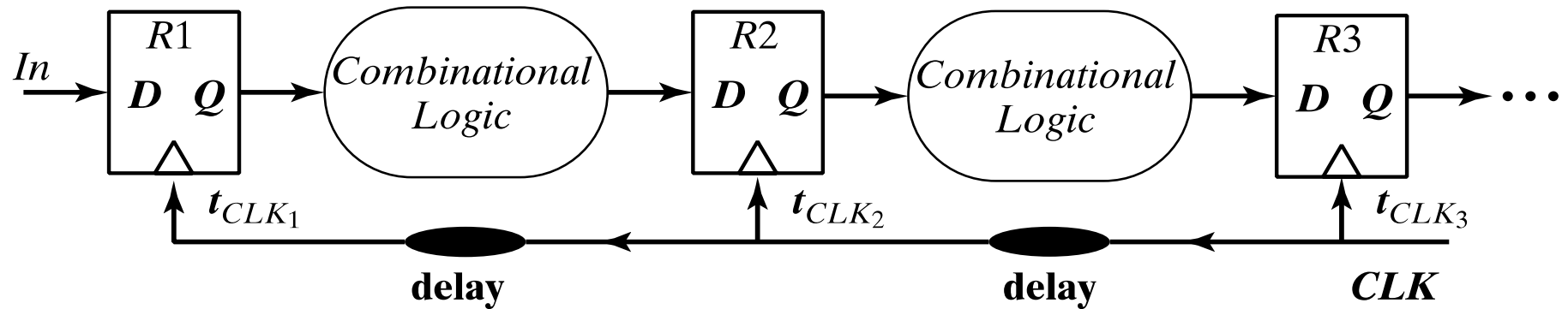
# Clock Skew and Jitter



- Both skew and jitter affect the effective cycle time and the race margin

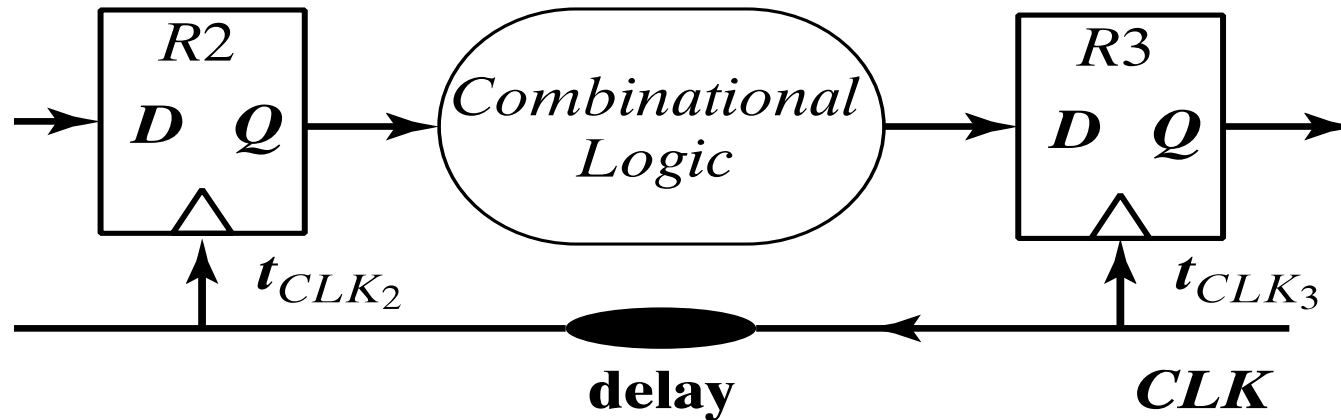


# Negative Skew



*Receiving edge arrives before the launching edge*

# Timing Constraints



$t_{clk-q,max}$   
 $t_{clk-q,min}$   
 $t_{setup}, t_{hold}$

$t_{logic,max}$   
 $t_{logic,min}$

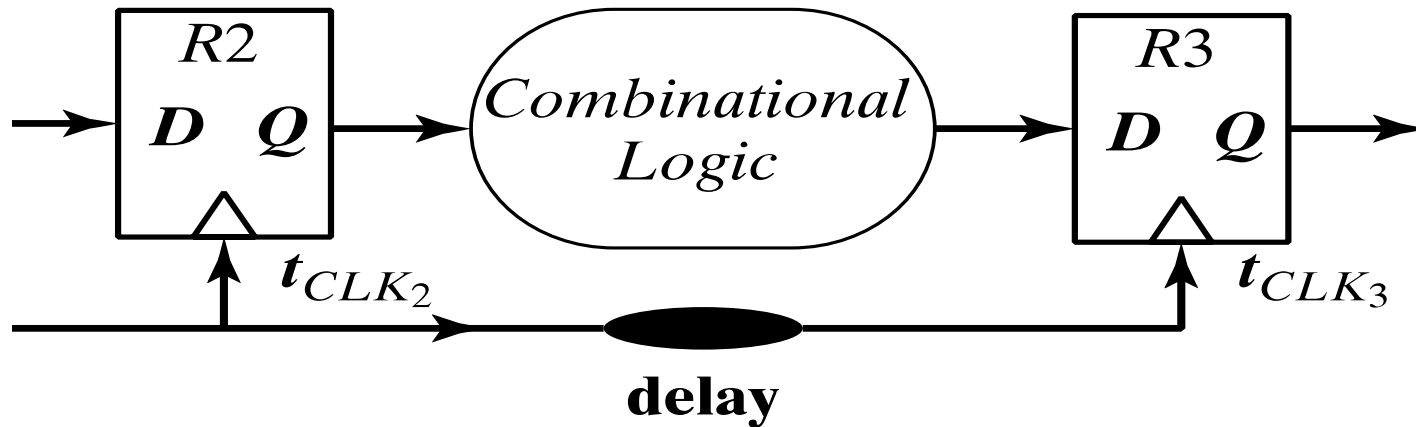
*Minimum cycle time:*

$$T_{clk} + \delta = t_{clk-q,max} + t_{setup} + t_{logic,max}$$

*Skew may be negative or positive*



# Timing Constraints



$t_{clk-q,max}$   
 $t_{clk-q,min}$   
 $t_{setup}, t_{hold}$

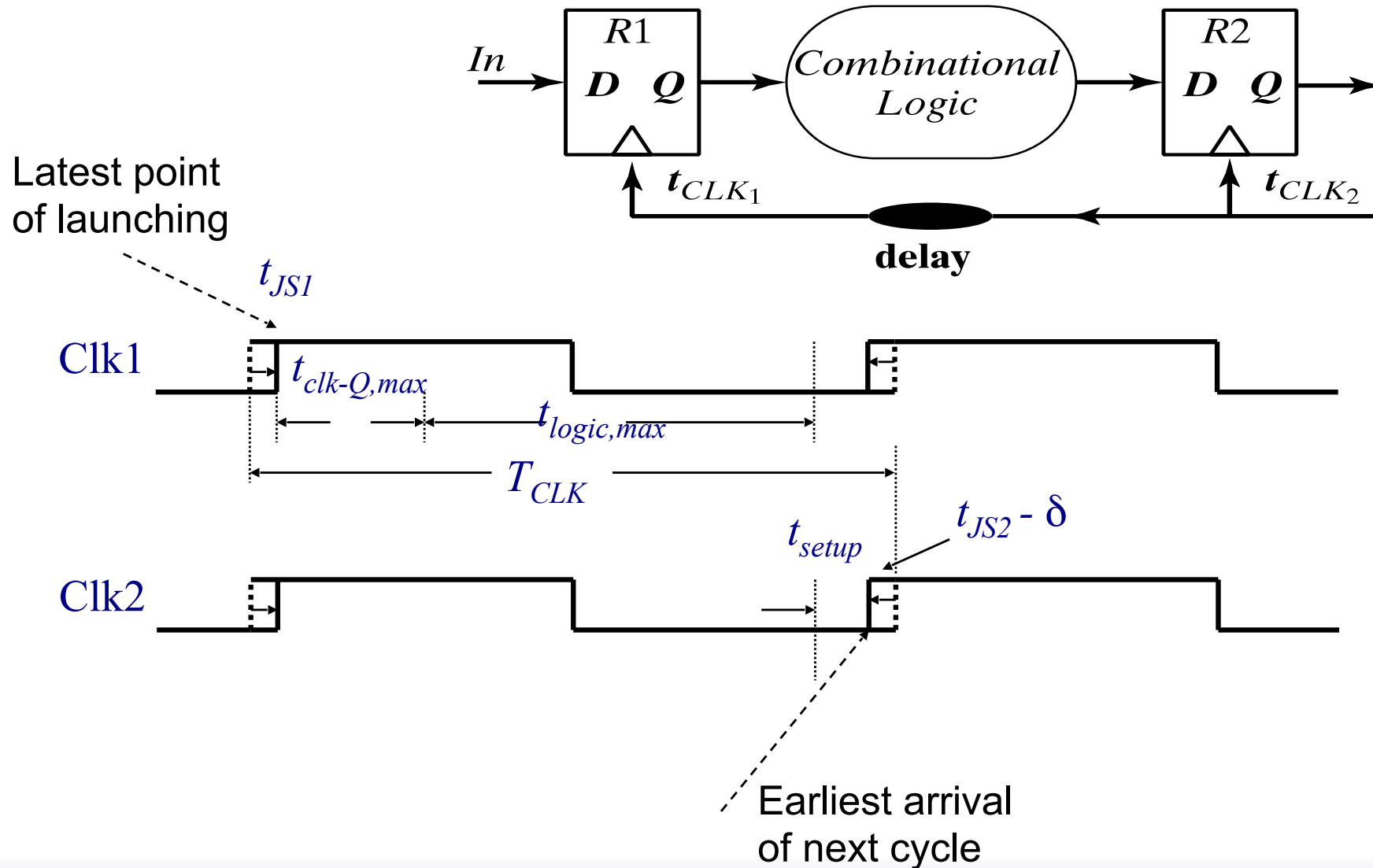
$t_{logic,max}$   
 $t_{logic,min}$

*Hold time constraint:*

$$t_{(clk-q,min)} + t_{(logic,min)} > t_{hold} + \delta$$

*Skew may be negative or positive*

# Jitter Contributes to Critical Path



# Clock Constraints in Edge-Triggered Systems

If launching edge is late and receiving edge is early, the data will not be too late if:

$$t_{clk-q,max} + t_{logic,max} + t_{setup} < T_{CLK} - t_{JS,1} - t_{JS,2} + \delta$$

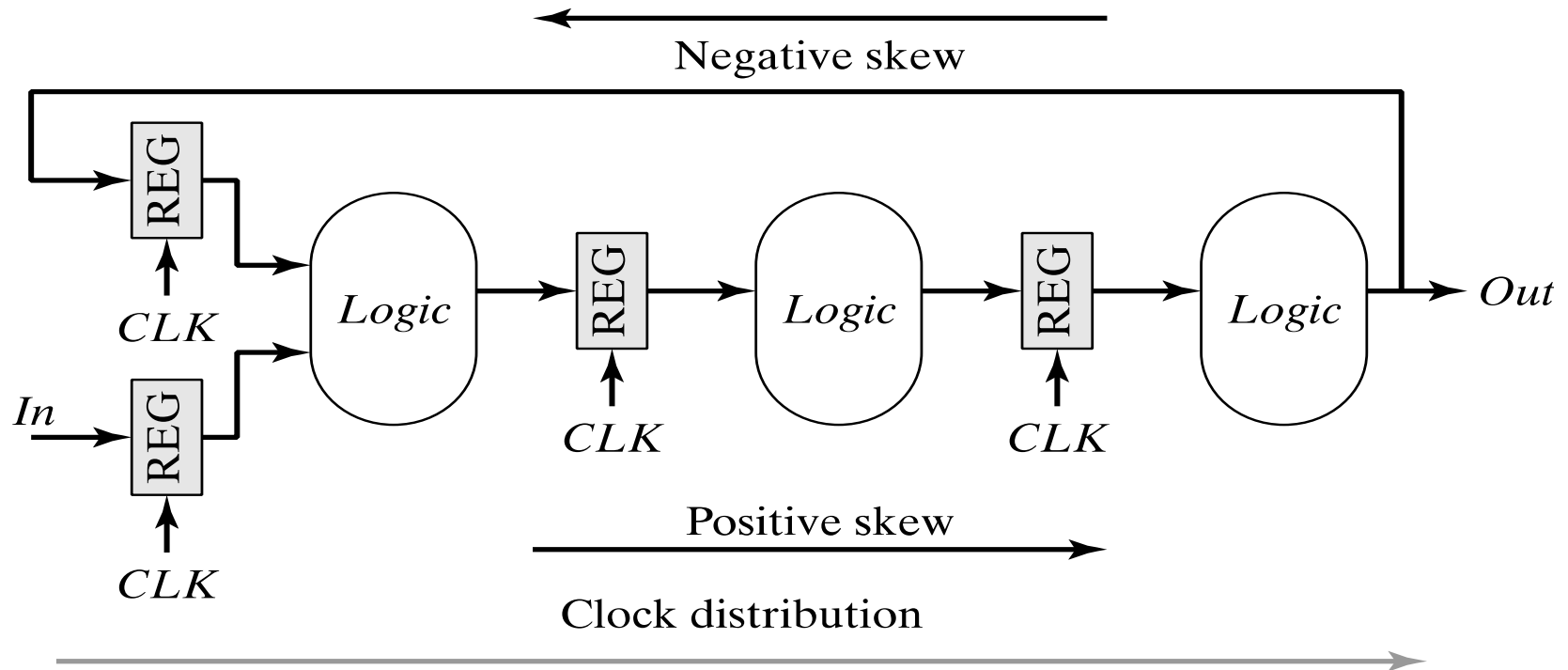
Minimum cycle time is determined by the maximum delays through the logic

$$t_{clk-q,max} + t_{logic,max} + t_{setup} - \delta + 2t_{JS} < T_{CLK}$$

Skew can be either positive or negative

Jitter  $t_{JS}$  usually expressed as peak-to-peak or  $n \times$  RMS value

# Datapath with Feedback





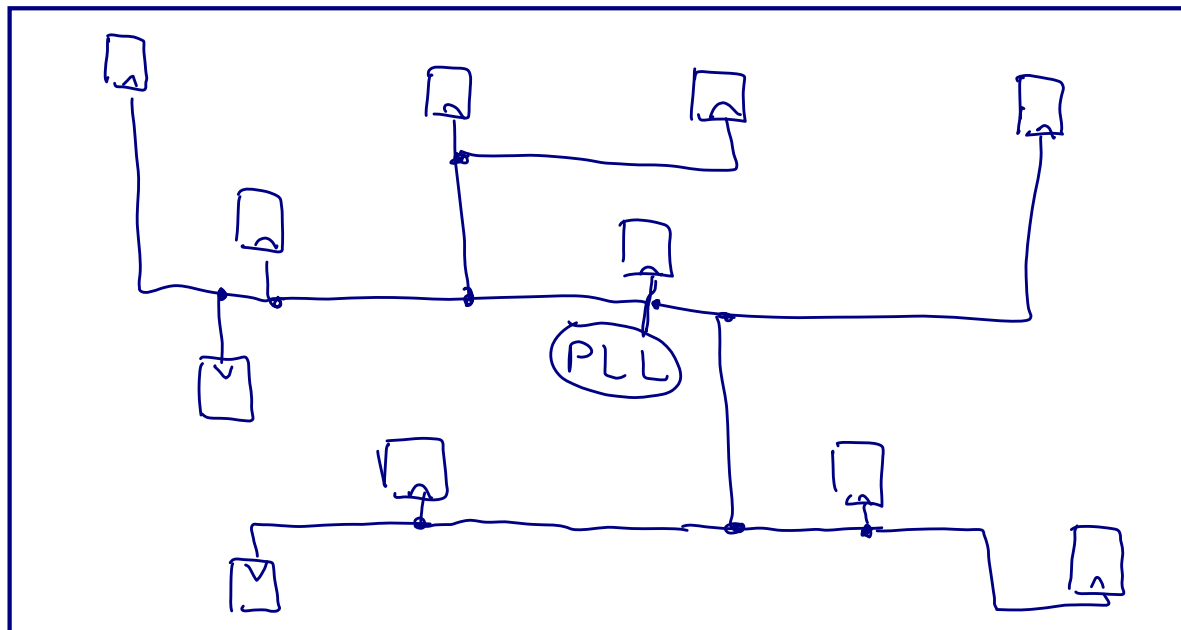
## Clock Distribution

# *Clock Distribution*

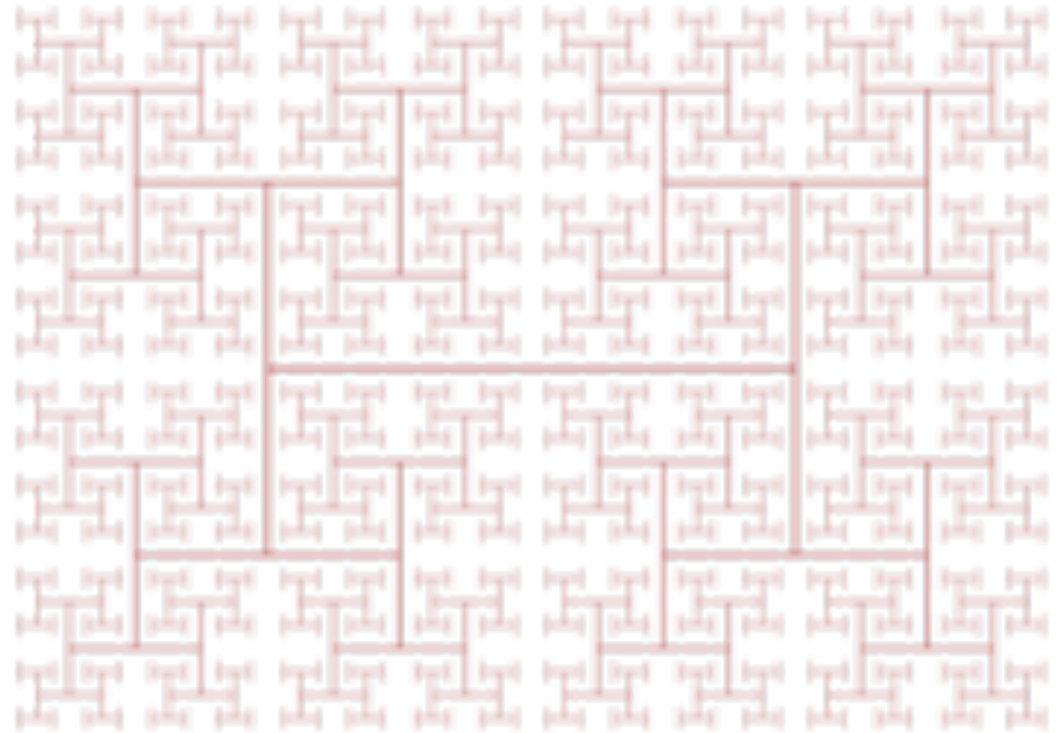
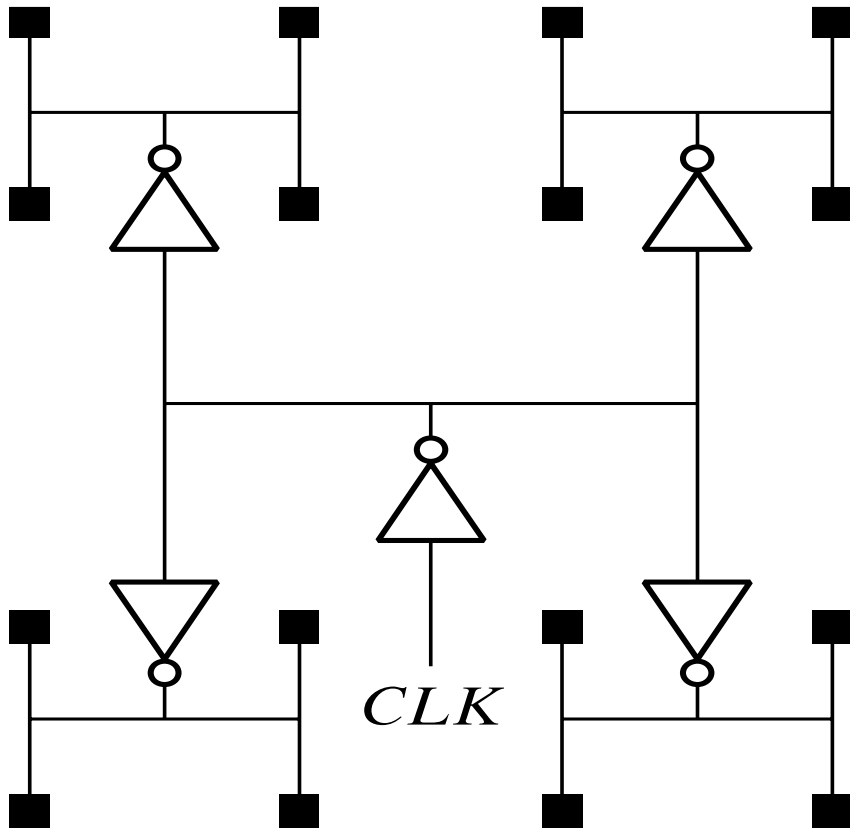
- Single clock generally used to synchronize all logic on the same chip (or region of chip)
  - Need to distribute clock over the entire region
  - While maintaining low skew/jitter
  - And without burning too much power

# Clock Distribution

- ❑ What's wrong with just routing wires to every point that needs a clock?



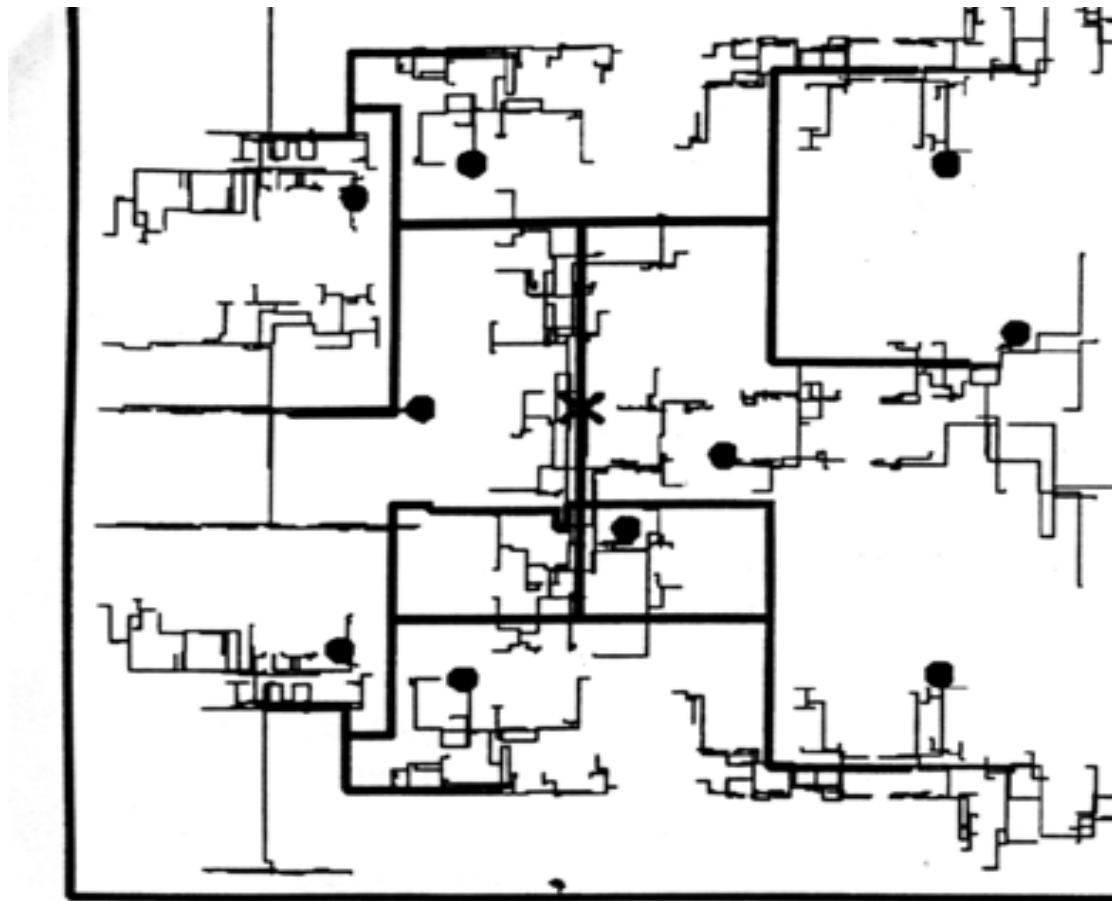
# H-Tree



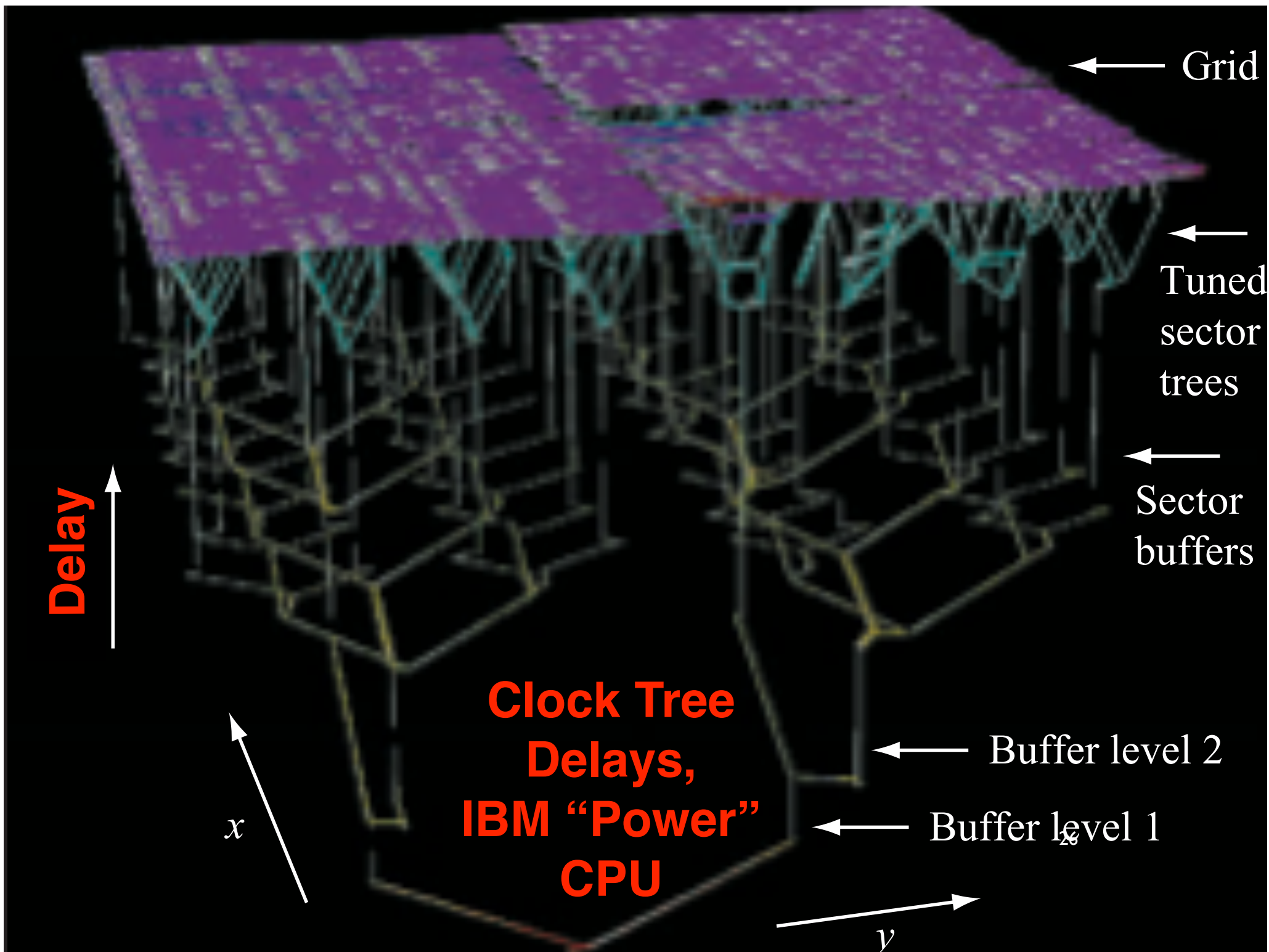
Equal wire length/number of buffers to get to every location

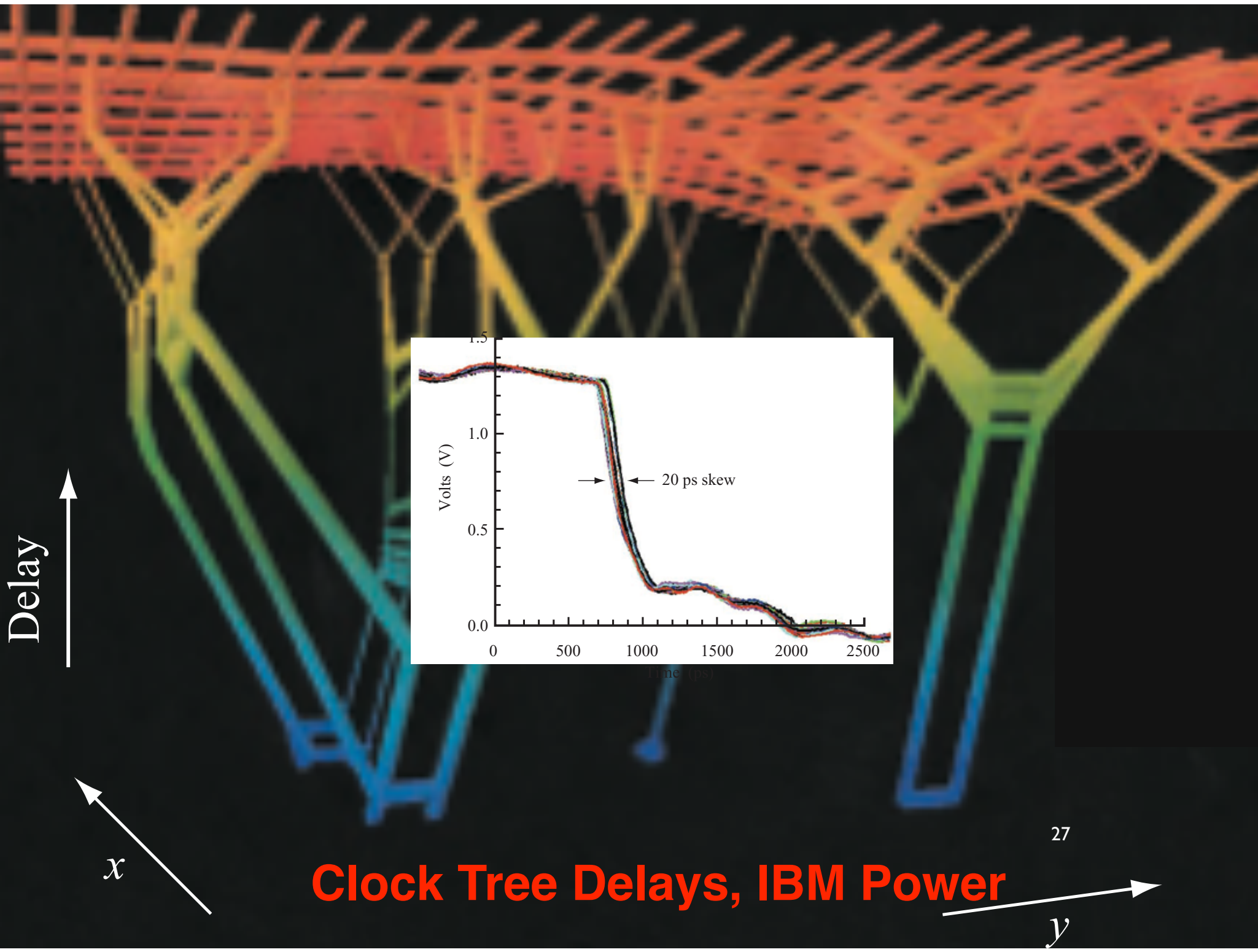


# *More realistic ASIC H-tree*



*[Restle98]*





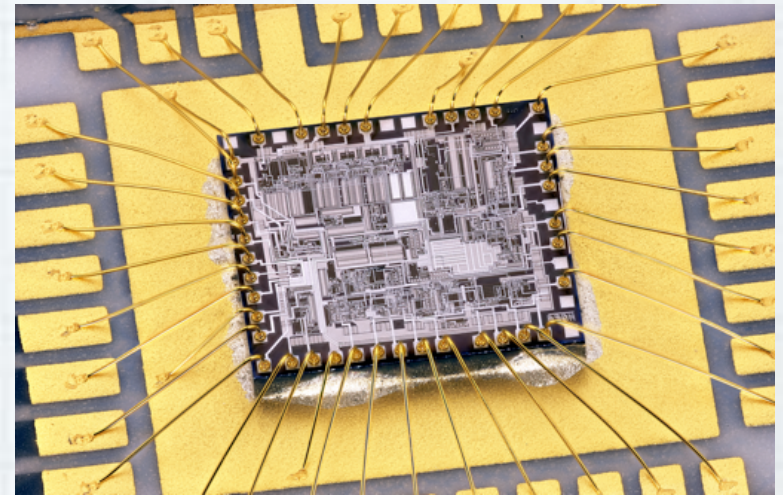
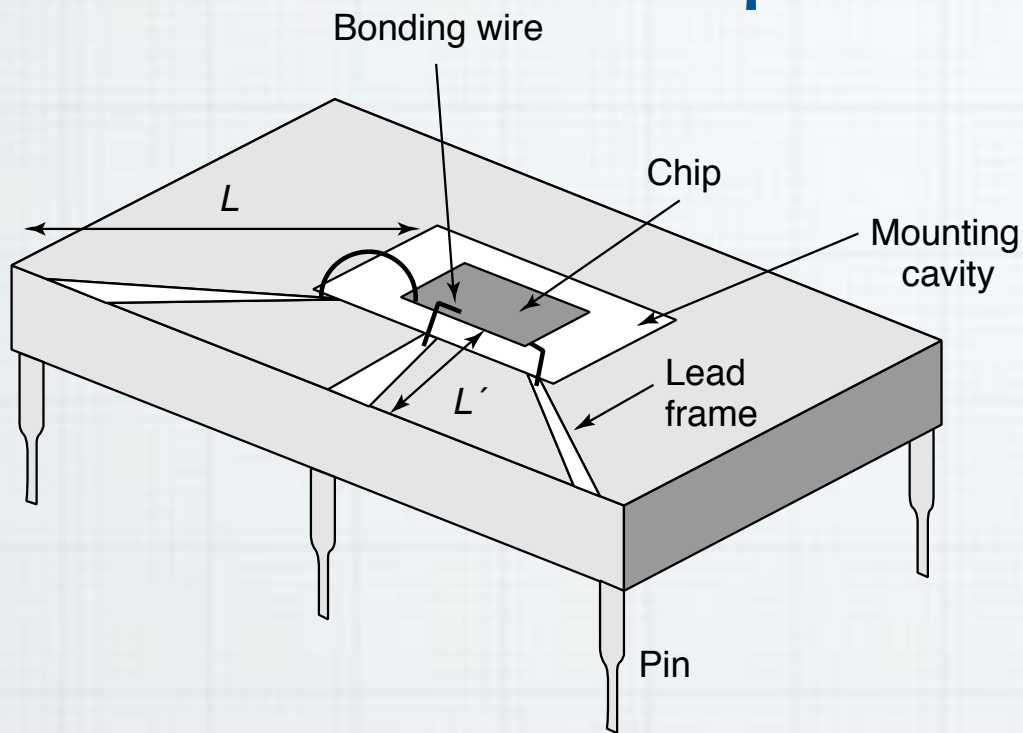
# Clock Tree Delays, IBM Power



## Chip Packaging



# Chip Packaging

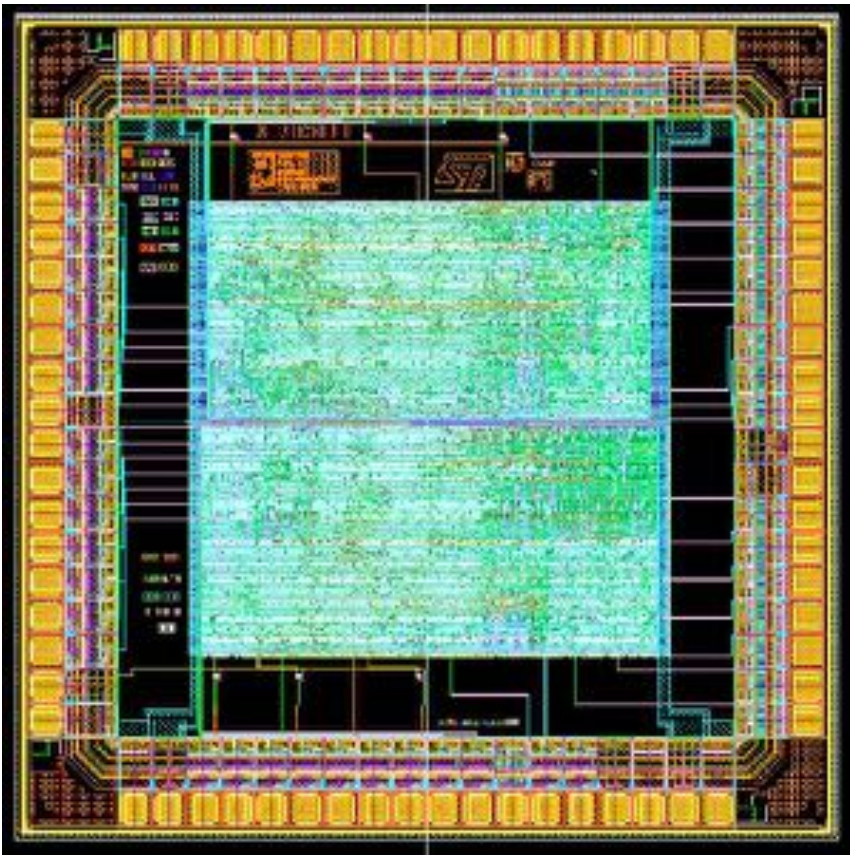


*Wikipedia*

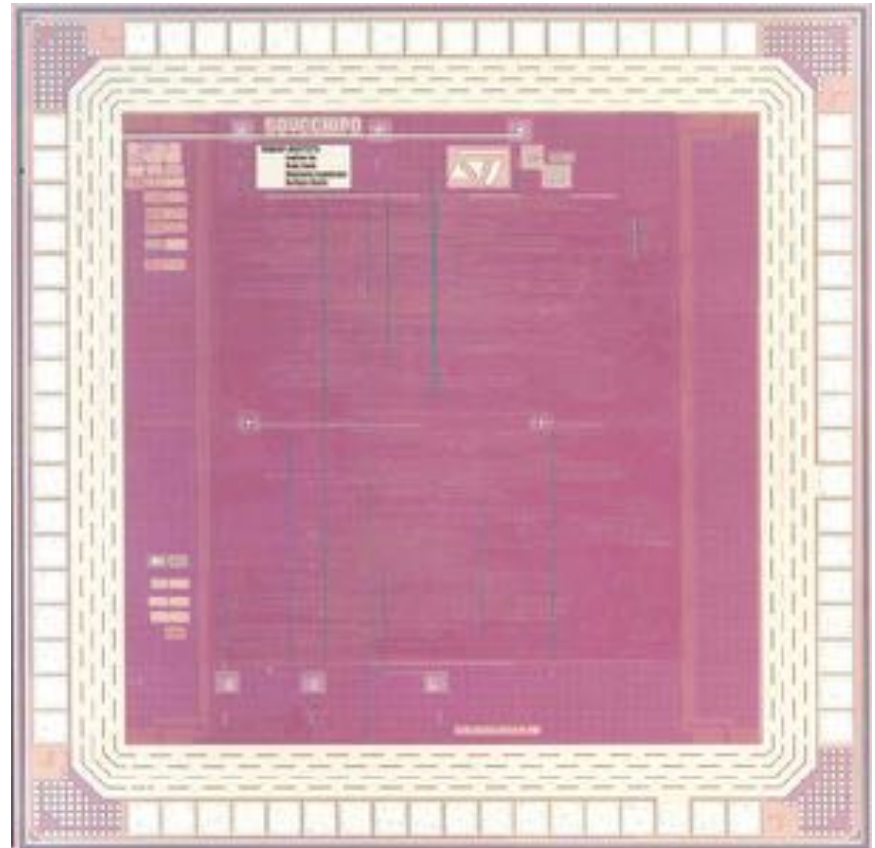
- ▶ Bond wires ( $\sim 25\mu\text{m}$ ) sometimes used to connect the package to the chip
- ▶ Pads are arranged in a frame around the chip
- ▶ Pads are relatively large
  - ▶  $\sim 100\mu\text{m}$  in  $0.25\mu\text{m}$  technology, with  $100\mu\text{m}$  pitch
  - ▶  $60\mu\text{m} \times 80\mu\text{m}$  at  $80\mu\text{m}$  pitch in  $45\text{nm}$
- ▶ Many chips are 'pad limited'

# Pad Frame

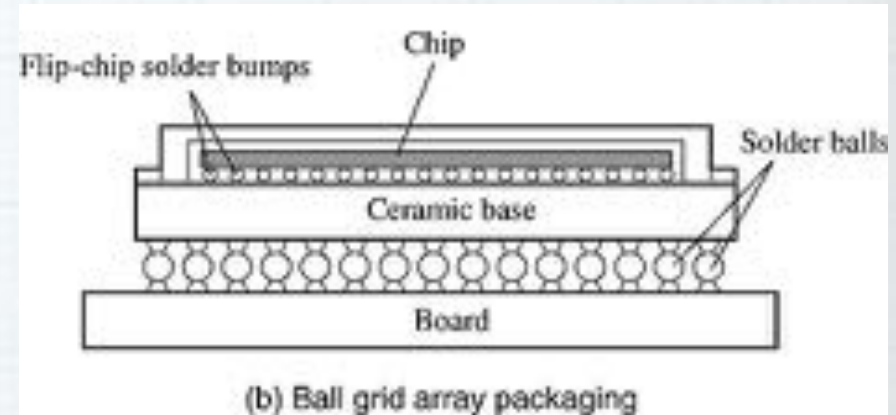
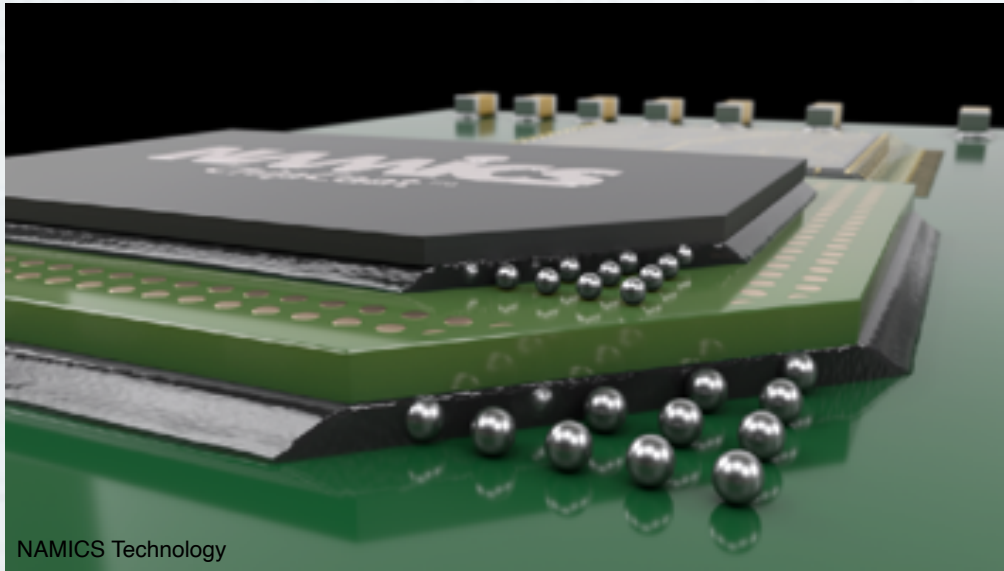
Layout



Die Photo



# Chip Packaging

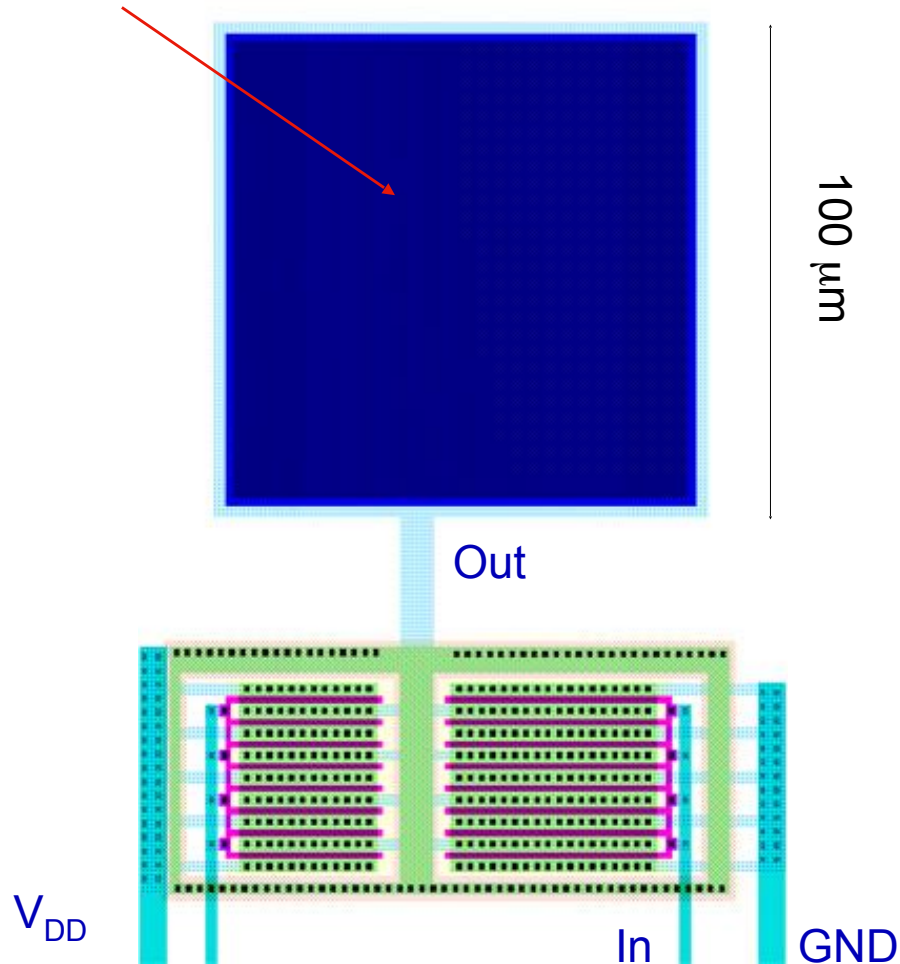


- ▶ Newer alternative is ‘flip-chip’:
  - ▶ Pads are distributed around the chip
  - ▶ The solder balls are placed on pads
  - ▶ The chip is ‘flipped’ onto the package
  - ▶ Pads still large
    - ▶ But can have many more of them

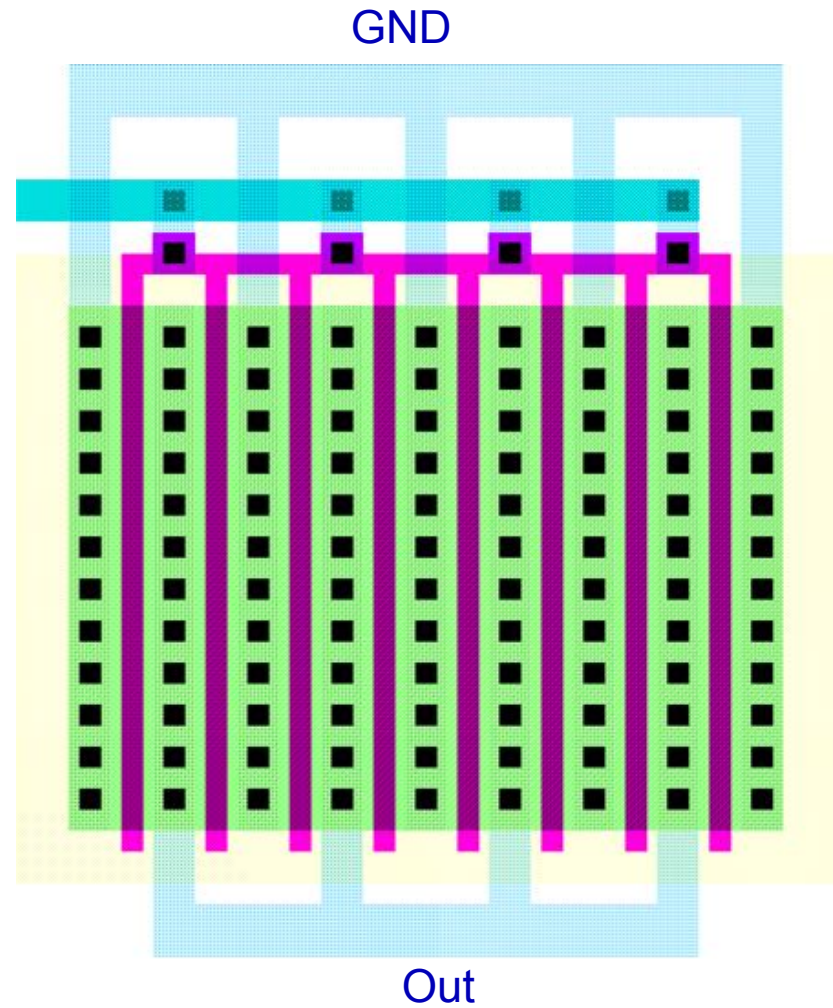


# Bonding Pad Design

Bonding Pad



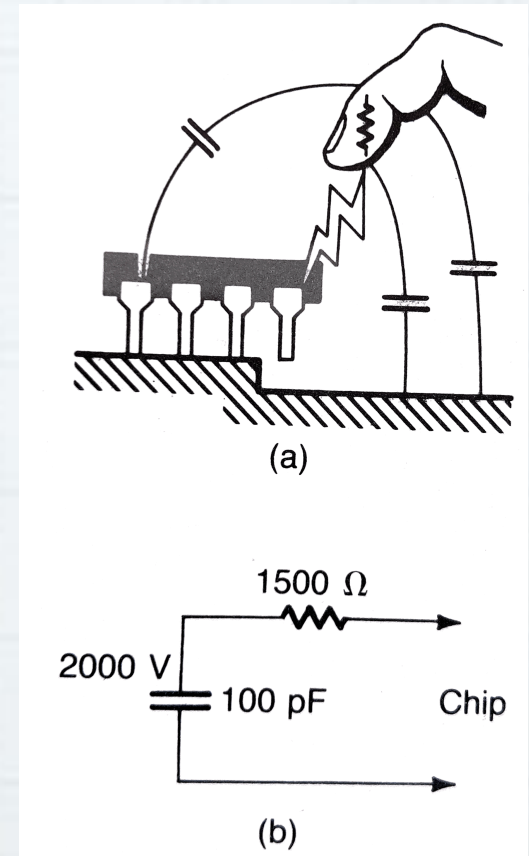
100  $\mu\text{m}$





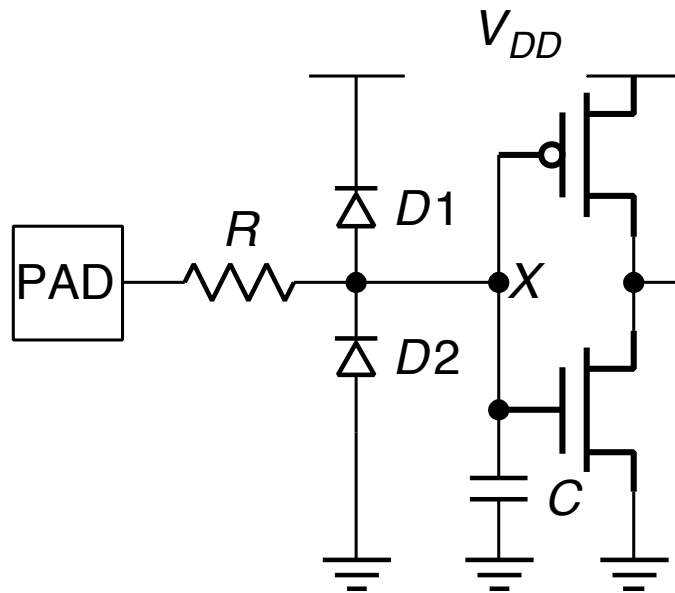
# ESD Protection

- ▶ When a chip is connected to a board or otherwise handled, there is unknown (potentially large) static voltage difference (a few kV)
- ▶ Equalizing potentials requires (large) charge flow through the pads
- ▶ Diodes sink this charge into the substrate – need guard rings to pick it up.

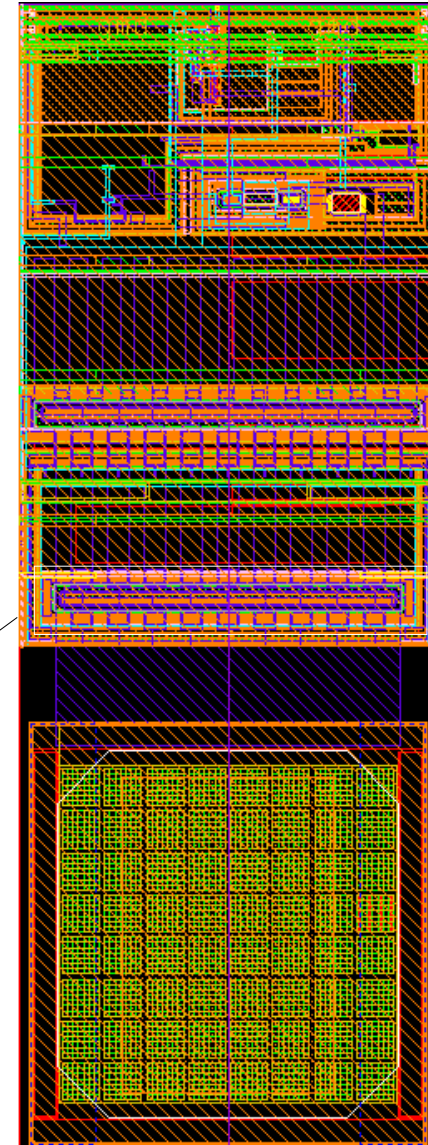
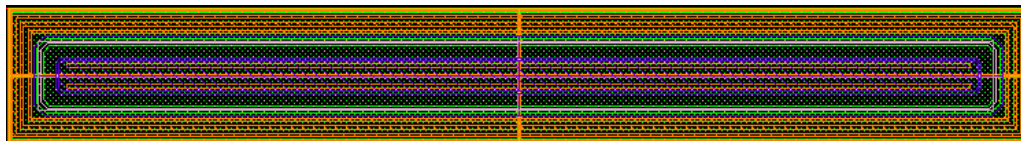


*The Design and Analysis of VLSI Circuits,  
Glasser and Dobberpuhl*

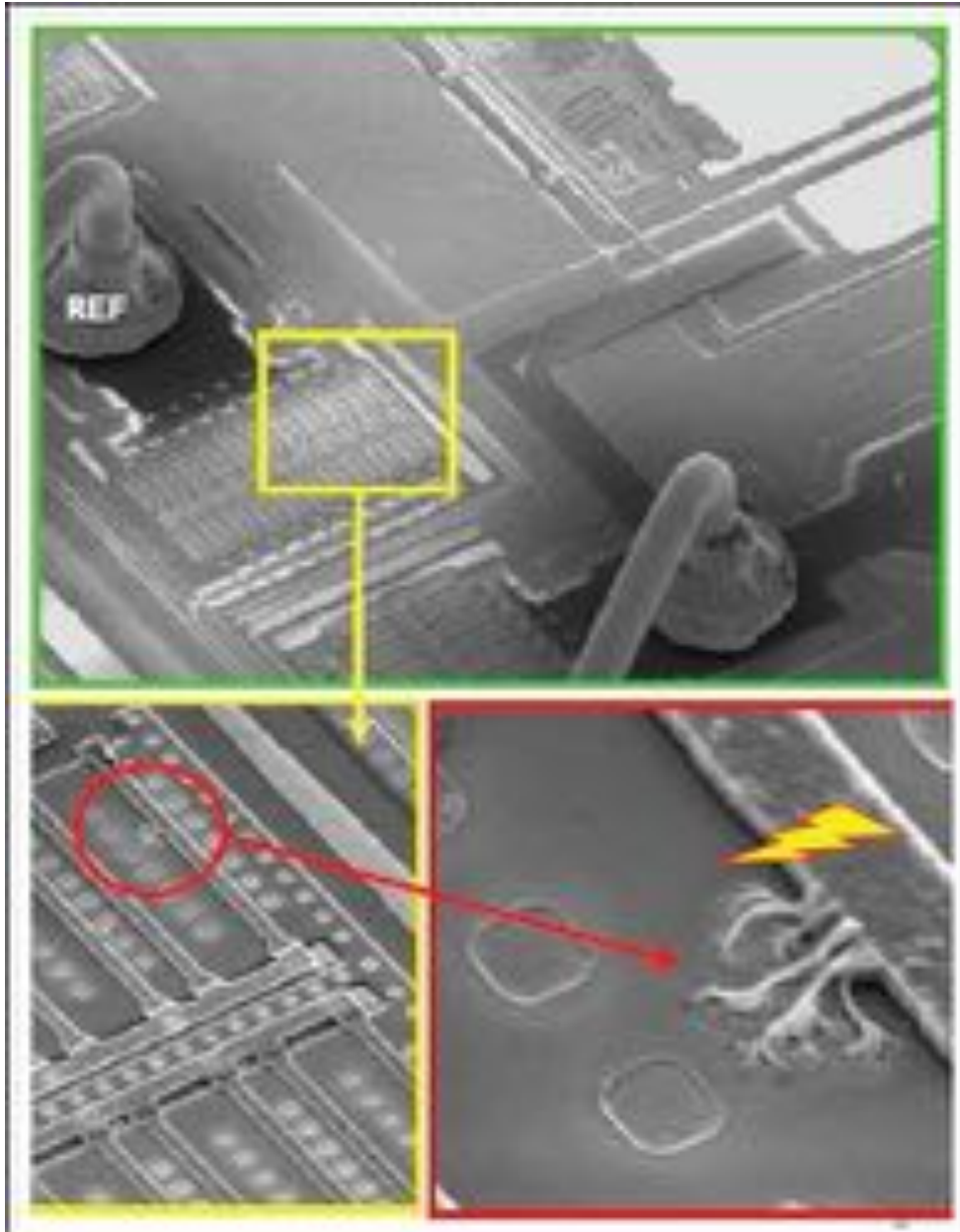
# Pads + ESD Protection



Diode



# When Things Go Bad



*[Maxim]*



## Power Distribution

# Power Supply Distribution Issues

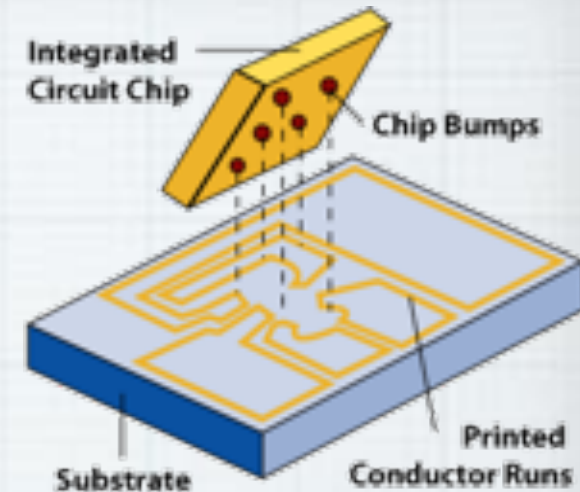
- ▶ **IR drops**
  - ▶ Voltage drops due to resistance in power wires
    - ▶ *Slower circuits, false switching*
- ▶ **Metal Migration (electromigration)**
  - ▶ *chip failures*
- ▶ **Inductive Effects**
  - ▶ bounce and oscillations on power nodes

All effects are helped by *shorter thicker wires*. Modern processes have special thick metal layers dedicated to power distribution. Area pads help keep connections to package short and distance from pad to circuit short.

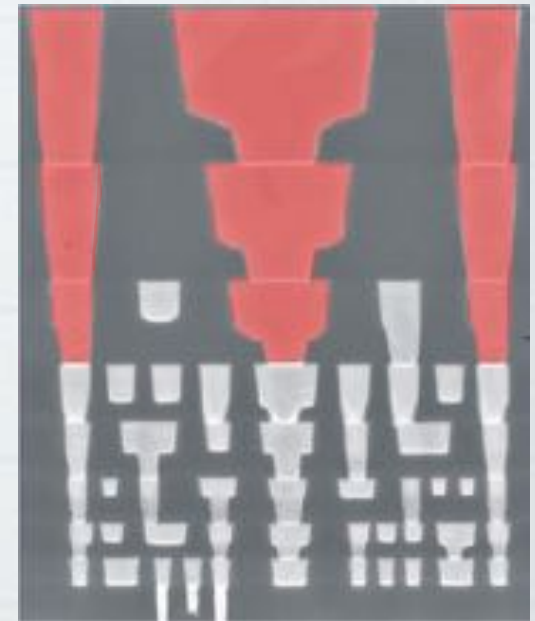


# Power Delivery

- ▶ Achieving good reliable power delivery requires a lot of resources:
  - ▶ ~70% of package pins just for power
  - ▶ Top 2-3 (thick) metal layers



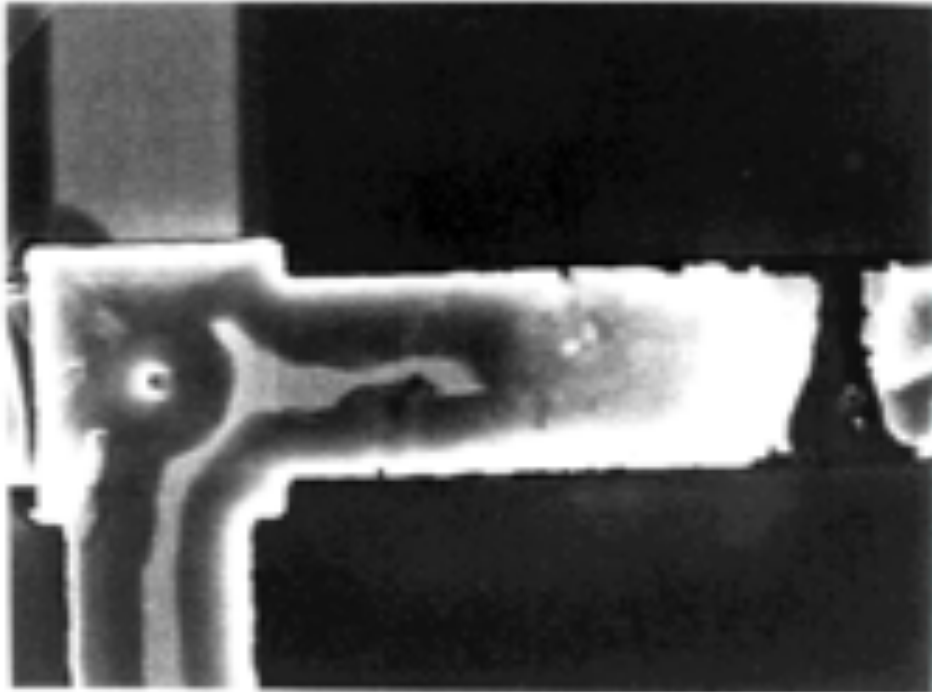
*Chip Metal Layers*



All effects are helped by *shorter thicker wires*.  
Modern processes have special thick metal layers dedicated to power distribution. Area pads help keep connections to package short and distance from pad to circuit short.

# Electromigration

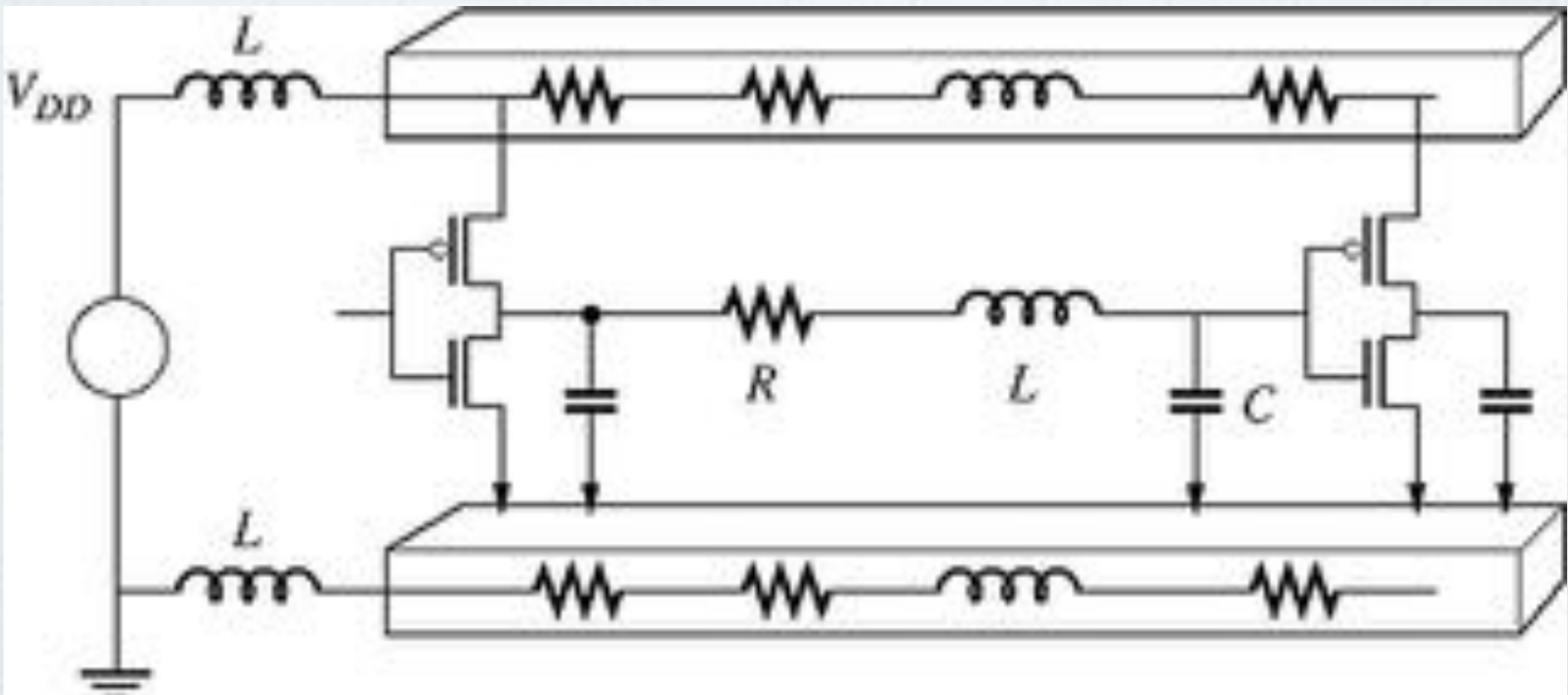
- If current density is too high - wires melts



- “On-chip wires: current limited to  $\sim 1\text{mA}/\mu\text{m}$  for 5-7 year lifetime

# Power Supply Impedance (Z)

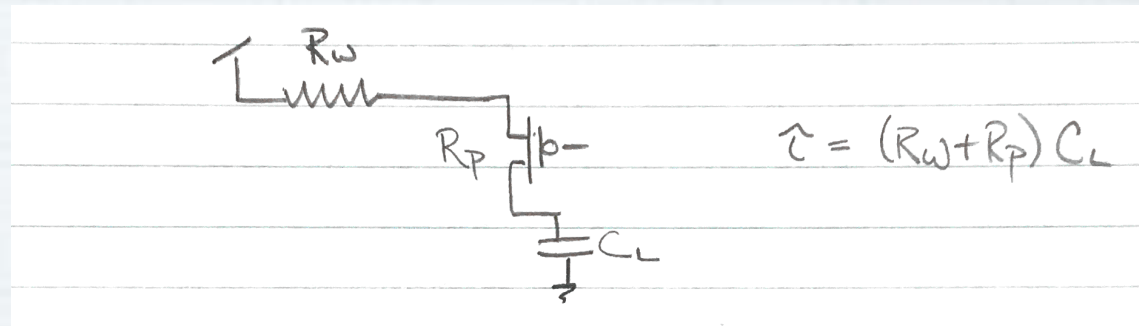
- ▶ Two principal elements increase Z:
  - ▶ Resistance of supply lines ( $V = IR$  drop)
  - ▶ Inductance of supply lines ( $V = L \cdot di/dt$  drop)



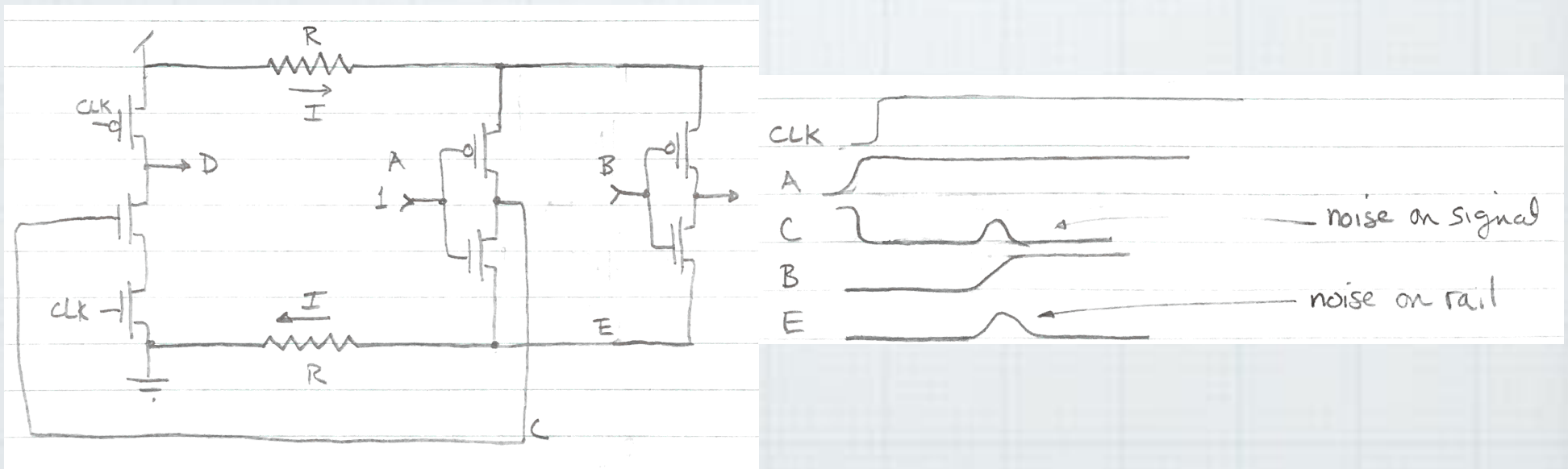


# Power Supply Impedance

- ▶ IR voltage drop
- ▶ Slower circuit operation because of series resistance with transistors:

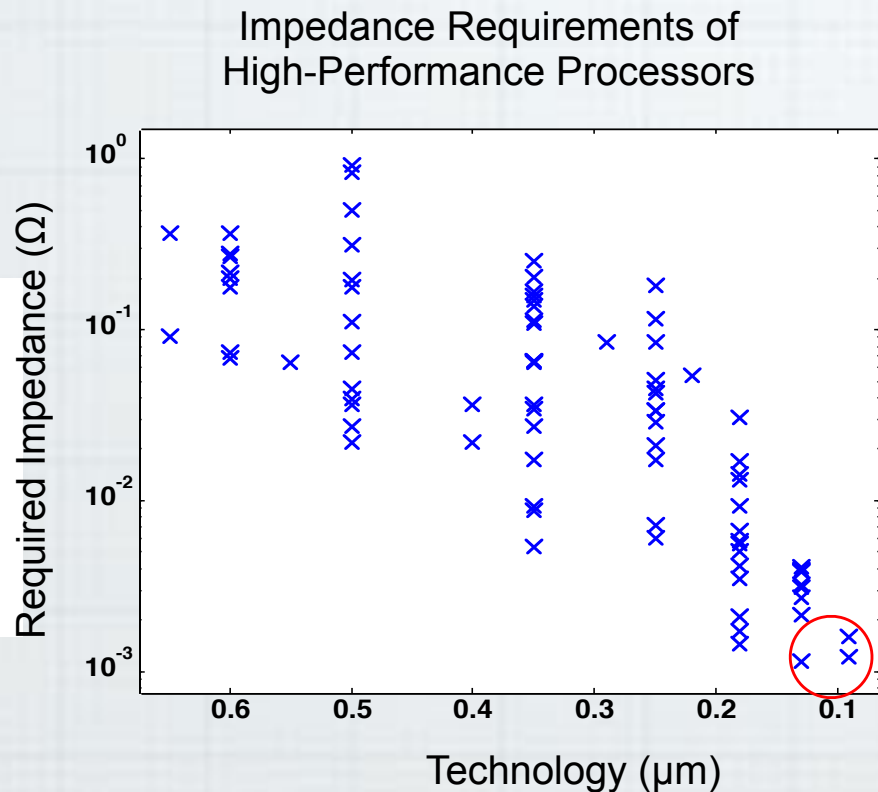


- ▶ IR drops generate “noise”:



# Scaling and Supply Impedance

- ▶ Typical target for supply impedance is to get 5-10% voltage variation of nominal supply (e.g., 100mV for 1V supply)



- In traditional scaling  $V_{dd}$  drops while power stays constant.
- This forced drastic drop in required supply impedance:
  - $V_{dd} \downarrow, I_{dd} \uparrow \rightarrow |Z_{required}| \downarrow \downarrow$
- Extreme example:
  - $V_{dd} = 1V, P=100W \Rightarrow I_{dd}=100A$
  - For  $\Delta V_{dd,max} = 100mV,$   
 $Z_{dd,max} = 100mV/100A = 1m\Omega!$

# IR Drop Example

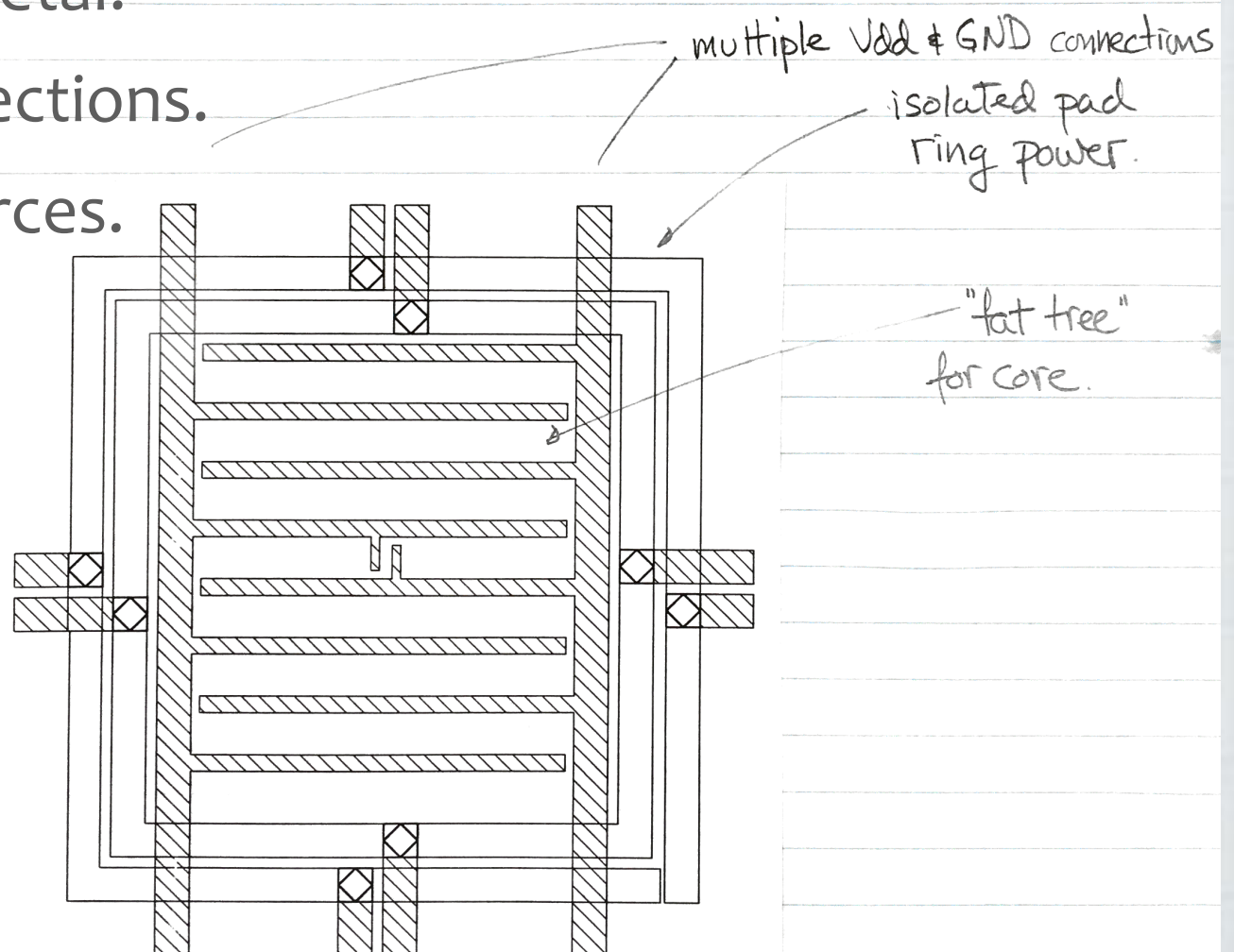
- ▶ Intel Pentium 4: ~103W at ~1.275V

$$I_{dd} = 81\text{Amps}$$

- ▶ For 10% IR drop, total distribution resistance must be less than **1.6mΩ**
- ▶ On-chip wire  $R \approx 20\text{m}\Omega/\text{sq.}$  (thick metal)
  - ▶ Can't meet R requirement even with multiple, complete layers dedicated to power
  - ▶ Main motivation for flip-chip packaging

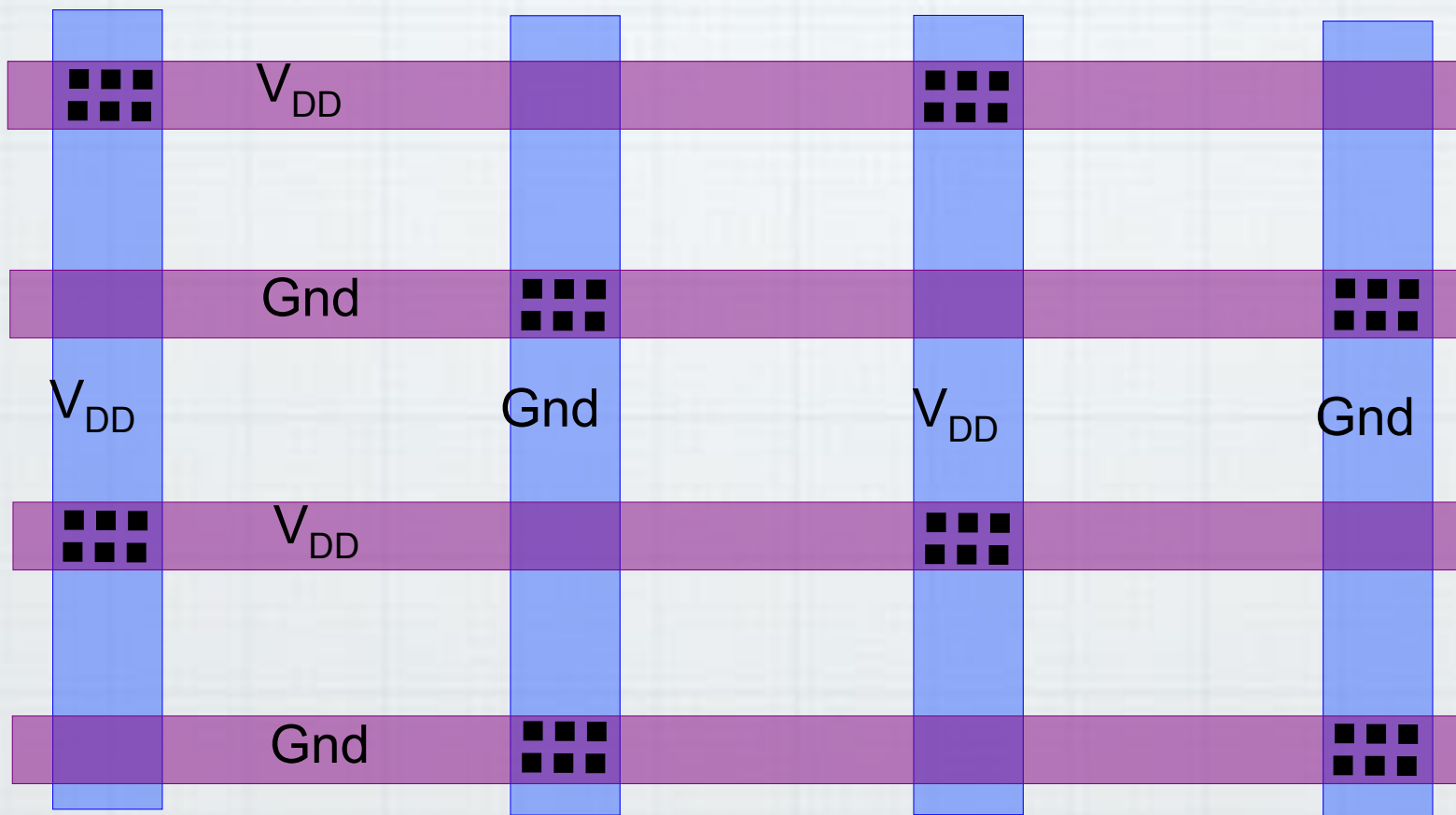
# Layout Strategy

1. Keep distance from source of power/gnd as short as possible.
2. Use wide thick metal.
3. Isolate "noisy" sections.
4. Use multiple sources.



# Popular On-Chip Power

- ▶ Power network usually follows pre-defined template (often referred to as “power grid”)

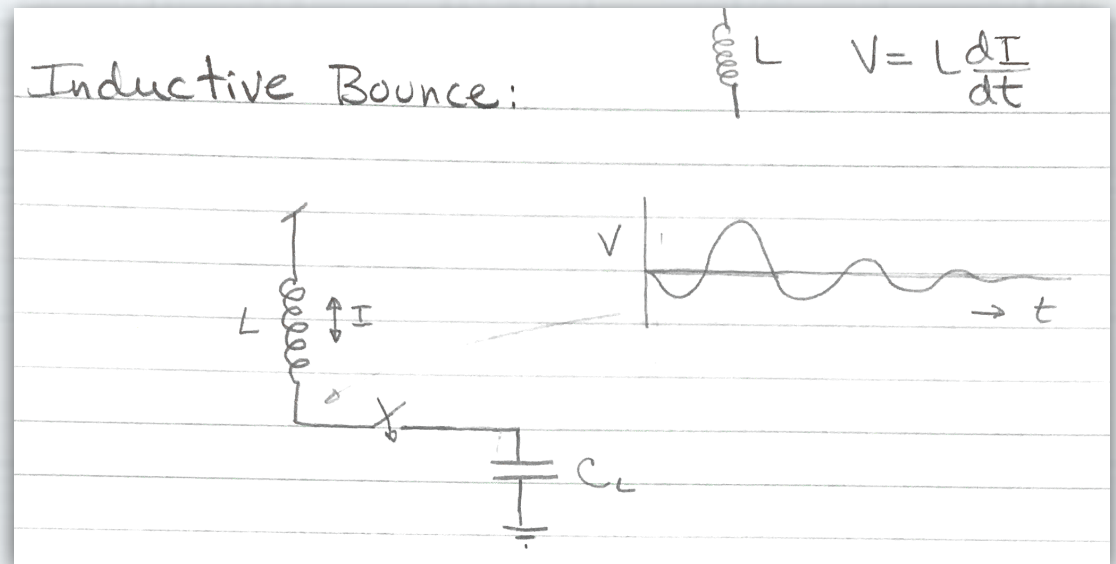


# Inductive Bounce

Inductance in the power & ground paths results in voltage glitches (noise) on the Vdd & GND nodes.

On chip L value of wires is small => usually not significant except:

1. Very large currents: clock drivers, off-chip drivers
2. Package pins, bonding wires (1nH/mm)



Package pins can have from 2 - 40nH of inductance, depending on package type

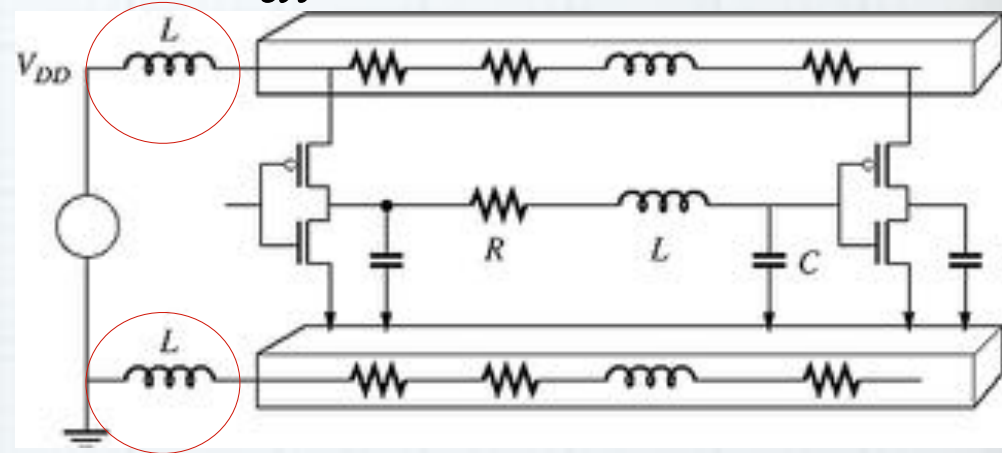
Strategy:

1. Use multiple bonding pads (wires) for Vdd and GND
2. Use on-chip bypass capacitors

# Pin Inductance

$$V = L \cdot \frac{dI}{dt}$$

- ▶ Major source of inductance is through the bonding pin connections to the chip package.
- ▶ C4 bump inductance is 25pH
- ▶ wire-bond inductance of 1nH/mm



## □ Example:

- Processor transient current is 50A in 20ps from 1V supply
- How many C4 bumps do we need to get supply noise spike of less than 10%?
- With wirebonds, how many wirebonds are needed?

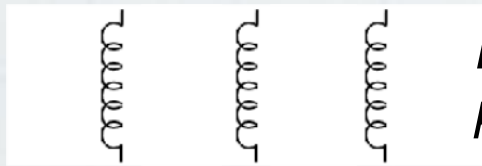


# Pin Inductance Example

- ▶ Processor transient current is 50A in 20ps from 1V supply:

$$V = L \cdot \frac{dI}{dt} \quad L = V \cdot \frac{dt}{dI} = 0.1V \cdot \frac{20ps}{50A} = 0.04pH$$

- ▶ C4 bump inductance is 25pH
- ▶ How many C4 bumps do we need to get supply noise spike of less than 10%?



*Inductors in parallel 1/add*

$$\frac{25pH}{0.04pH} = 625$$

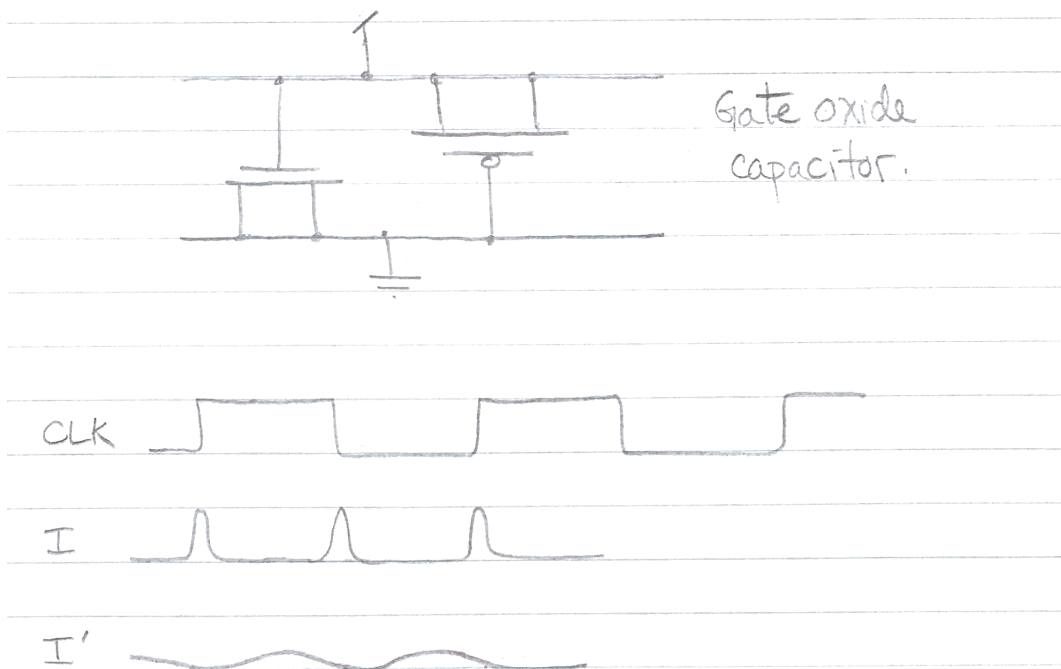
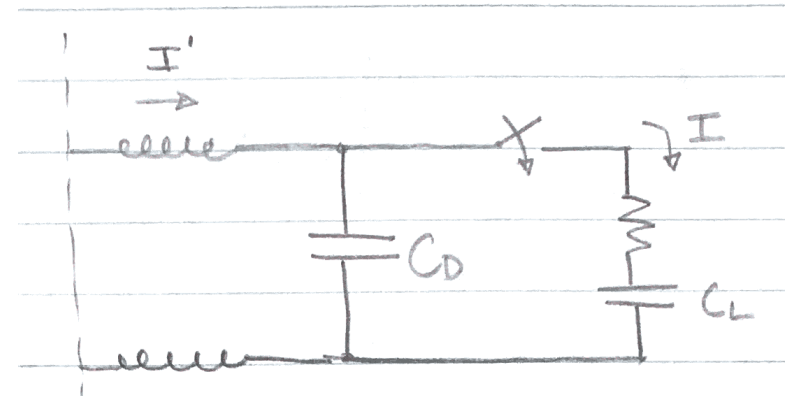
*C4 bumps*

$$\frac{1000pH}{0.04pH} > 25K!$$

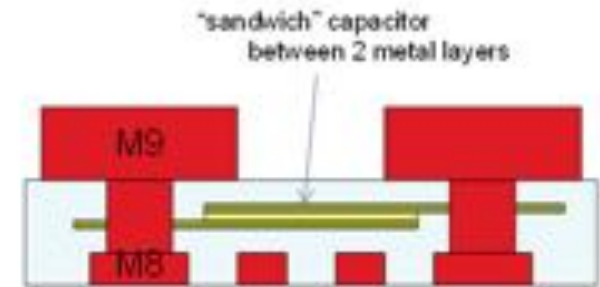
*bonding wires*

# On-chip Decoupling Capacitors Help with Inductive and Resistive Effects

- ▶ When transistors switch, current is drawn from  $C_D$  rather than through package pins and bonding wires - smooths our  $di/dt$ .
- ▶ Distributed bypass capacitors also smooth out noise from IR drops.

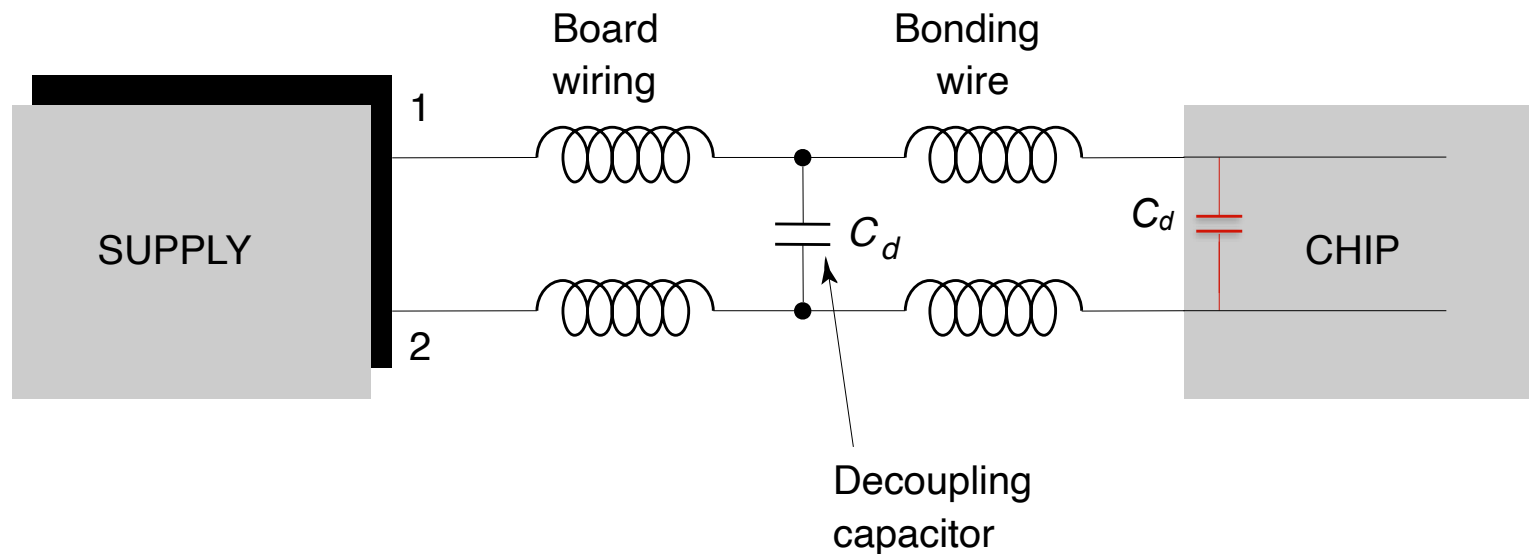


MIM Cap :density (20-30 ff/ $\mu\text{m}^2$ )



Decap cell in stdcell library added by tools.

# Decoupling Capacitors On-chip and on-board



## Decoupling capacitors are added:

- ❑ On the board (right under the supply pins)
- ❑ On the chip (under the supply straps, near large buffers)
- ❑  $C_d$  helps avoid current rushing through supply wires
  - ❑ local store of charge
  - ❑ “smoothing filter” on supply voltage

# Decoupling Capacitors

- ▶ Under the die

